

# SEM Report on Various Pulse Heating Samples and on SLAC X-Band Klystron Circuits

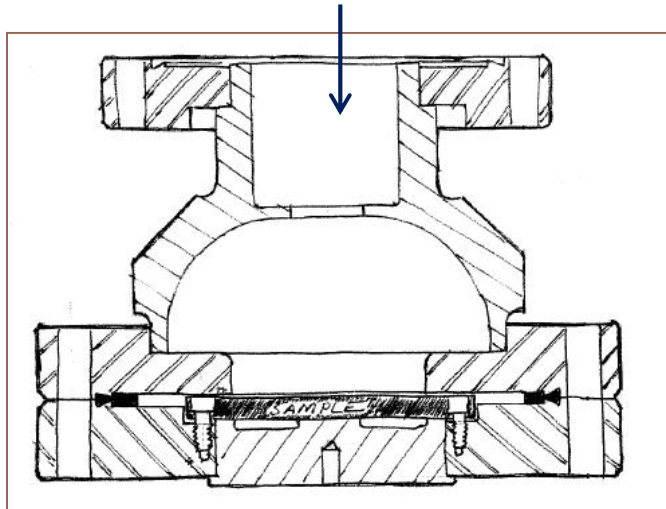
**SLAC:** L. Laurent, V. Dolgashev, A. Haase, A. Jensen, E. Jongewaard, J. Lewandowski, S. Tantawi,  
C. Yoneda, D. Yremian

**CERN:** M. Aicheler, G. Izquierdo, S. Heikkinen,

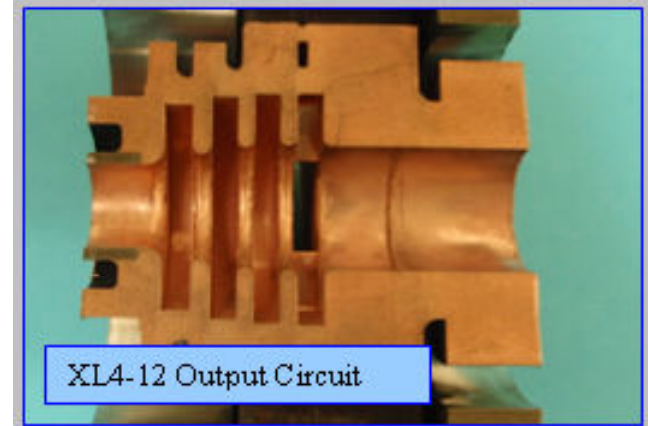
**KEK:** Y. Higashi

## Pulsed Heating Cavity

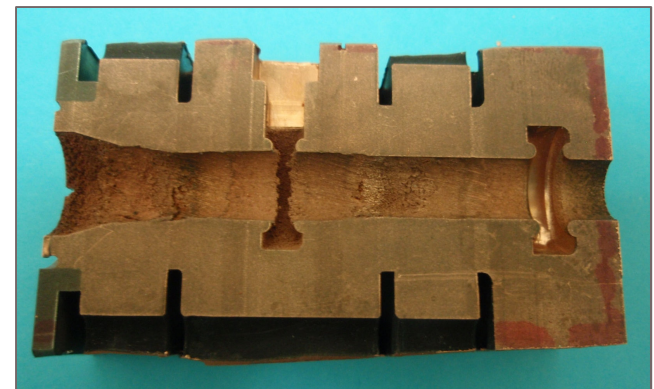
Pin



## XL and XP Klystron Circuits



## XL4-7 Input Circuit

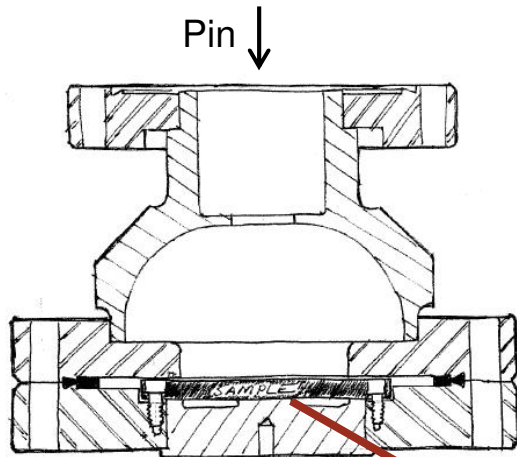


# Cavity Pulsed Heating Experiments

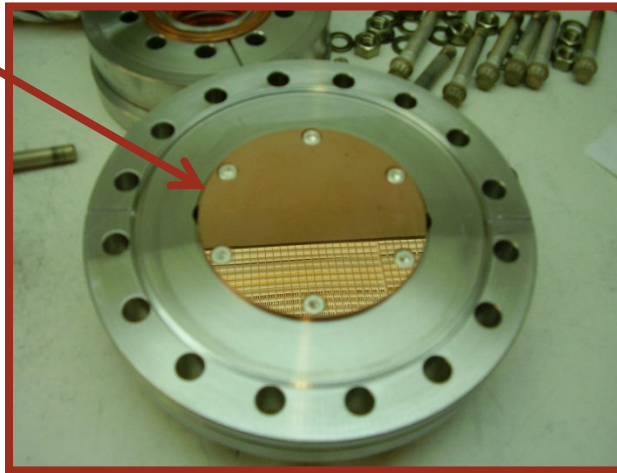
**SLAC:** L. Laurent, V. Dolgashev, J. Lewandowski, S. Tantawi, C. Yoneda, D. Yremian

**CERN:** M. Aicheler, G. Izquierdo, S. Heikkinen,

**KEK:** Y. Higashi



3-inch diam. pulse heating sample



Pulse Heating Samples RF  
Tested and presented at  
CLIC08



Cu101 (SLAC)

10



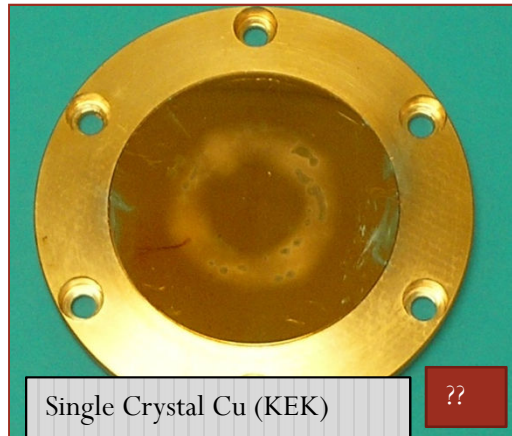
KEK3 (KEK)

19



HIP2 (KEK)

33



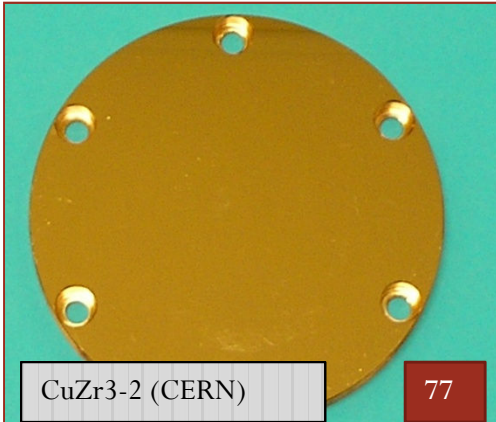
Single Crystal Cu (KEK)

??



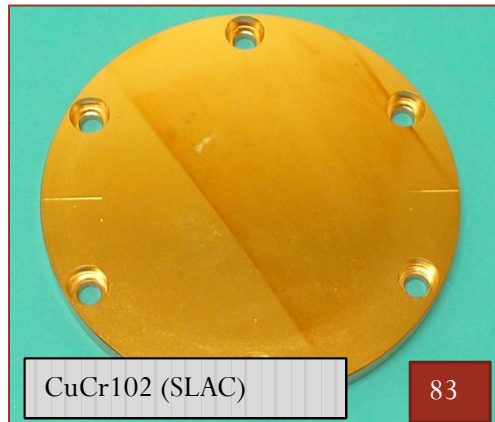
E-Deposited Cu (KEK)

62



CuZr3-2 (CERN)

77



CuCr102 (SLAC)

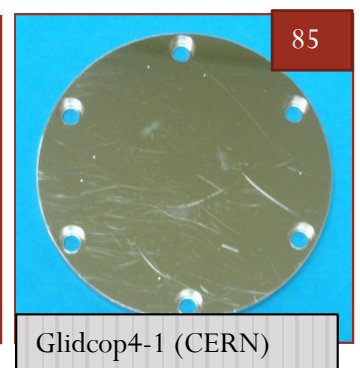
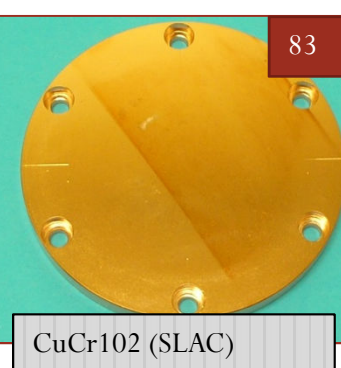
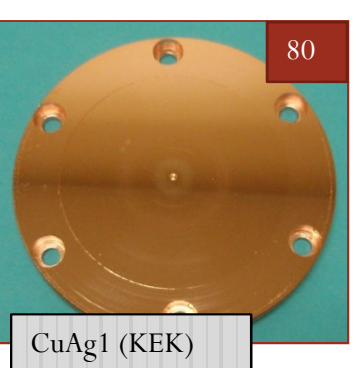
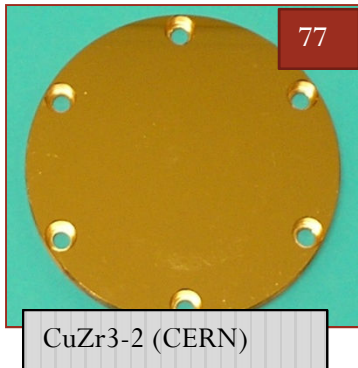
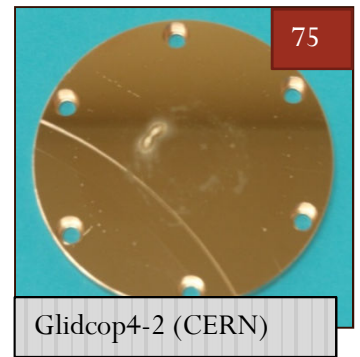
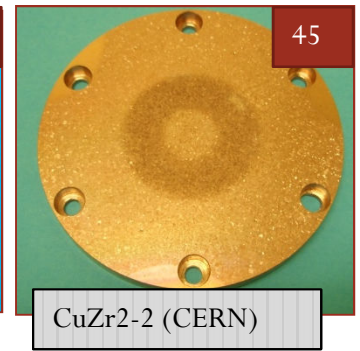
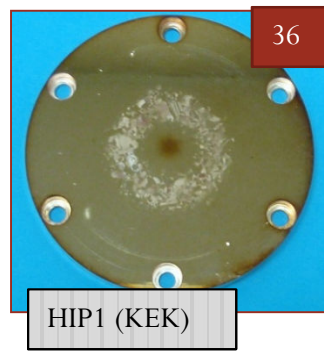
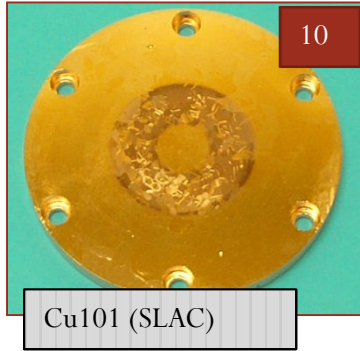
83

Hardness Test Value



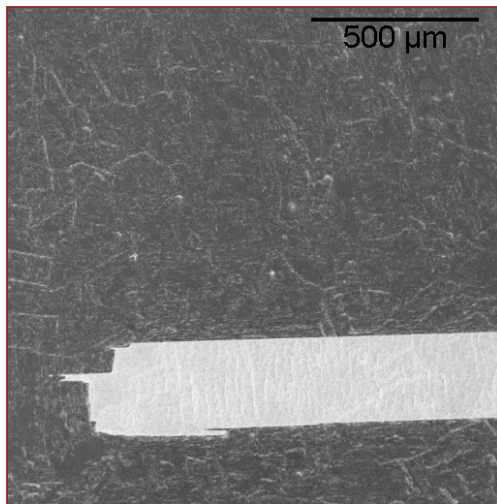
Hardness Test Value

Pulse Heating Samples (CLIC09)





Copper (KEK3 )

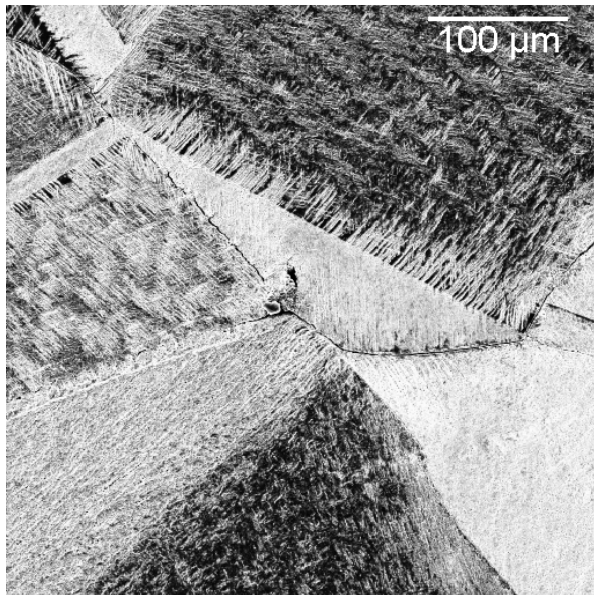


Pulse Heating Test Protocol:

10e7 Pulses

T = 110°C

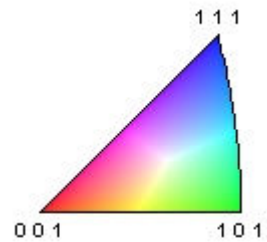
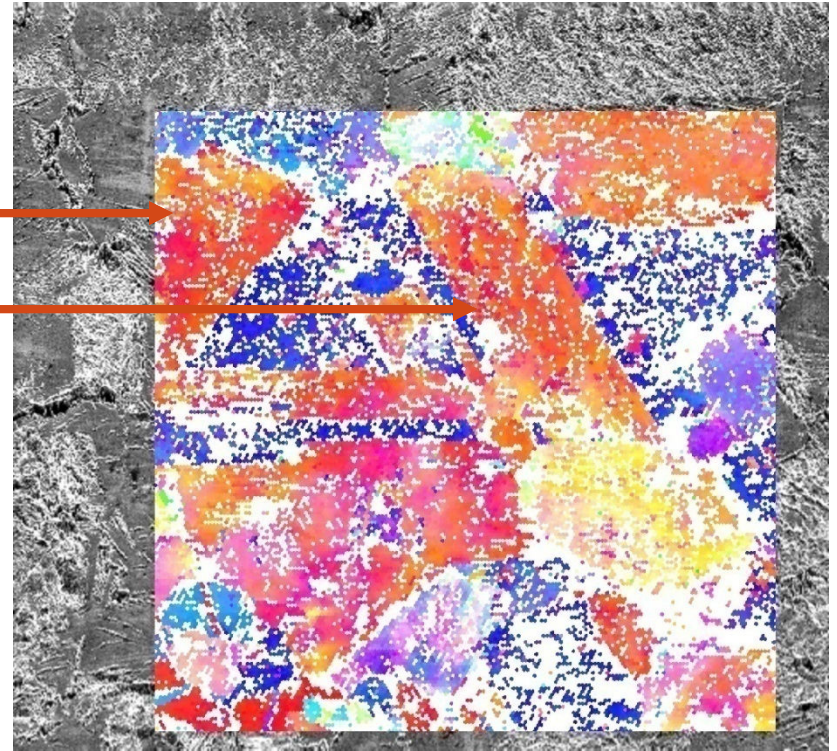
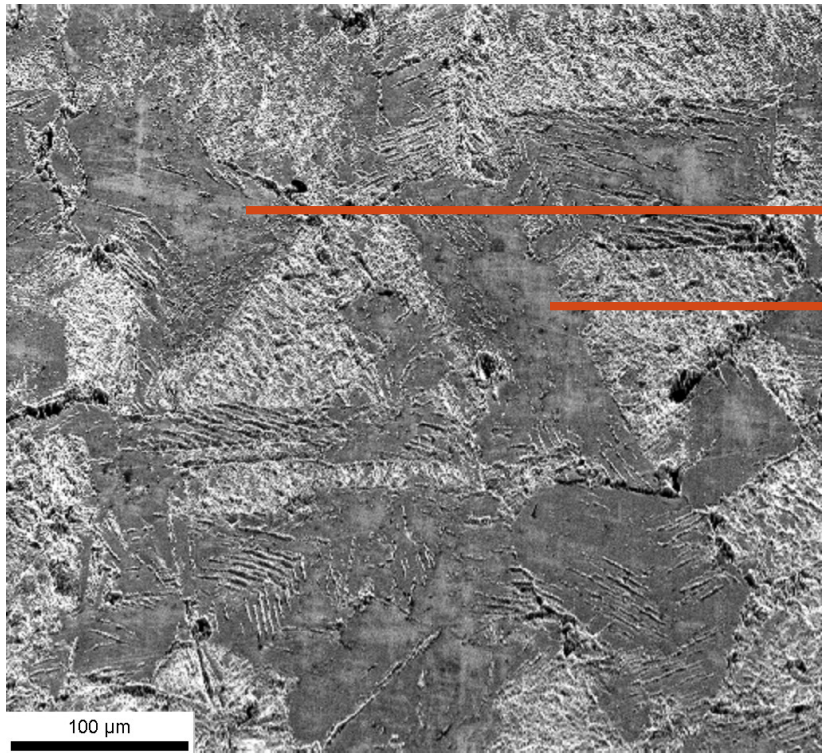
HIP2 Cu (KEK)





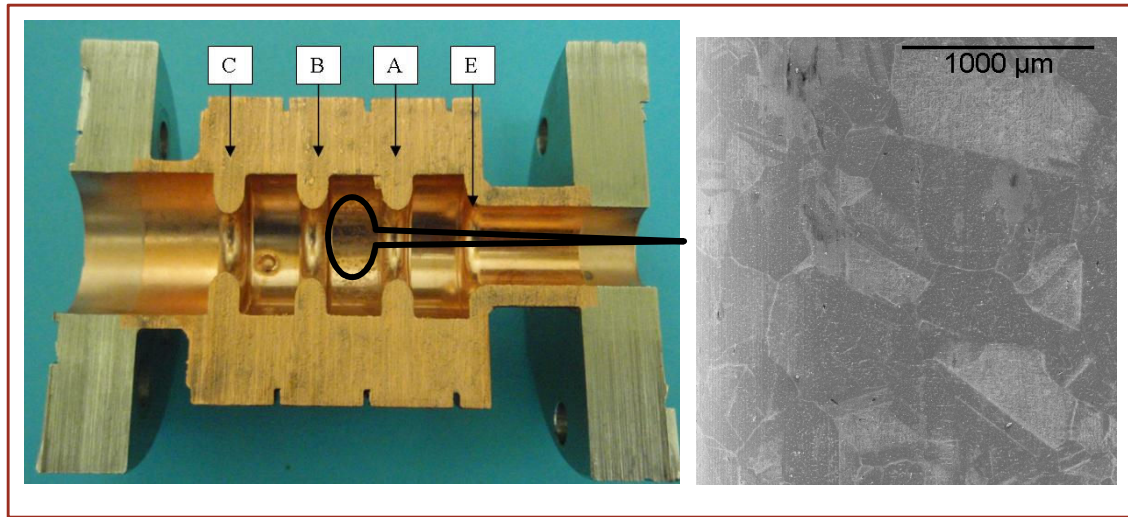
# Electron Back Scattered Diffraction

Courtesy of Markus Aicheler (CERN)

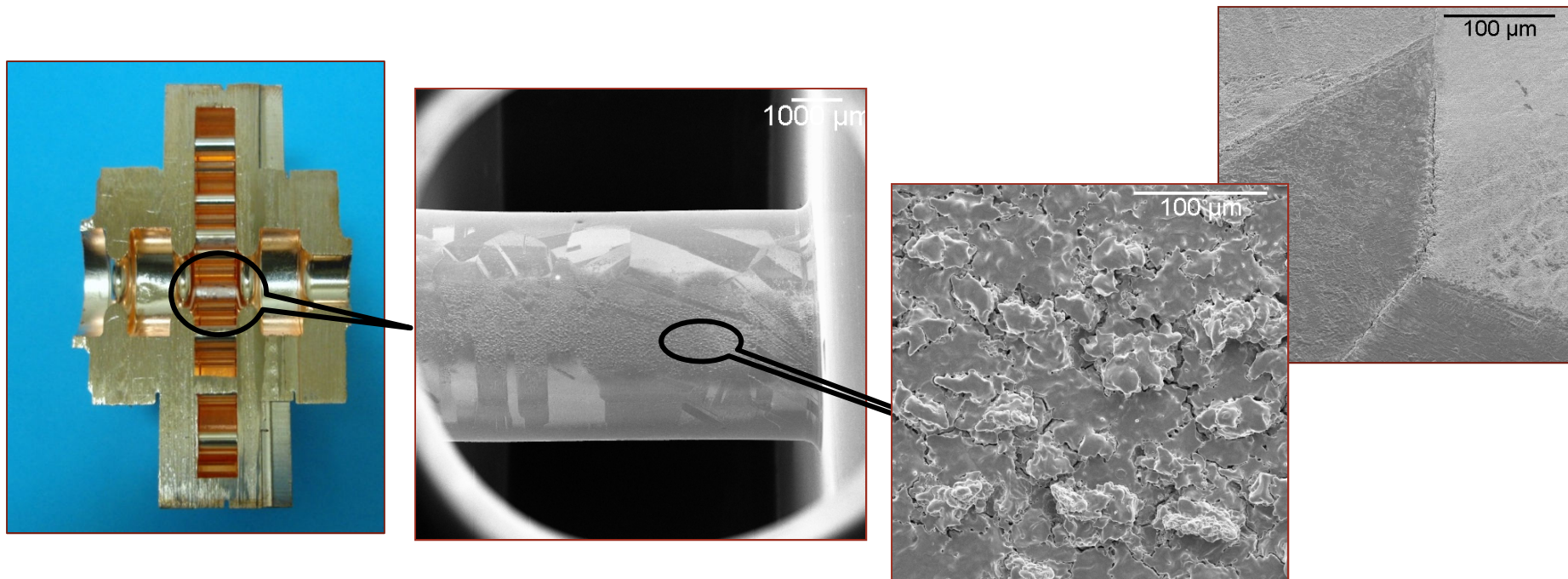




## CuZr Single Cell Structure (1C-SW-A5.65-T4.6-CuZr-SLAC)

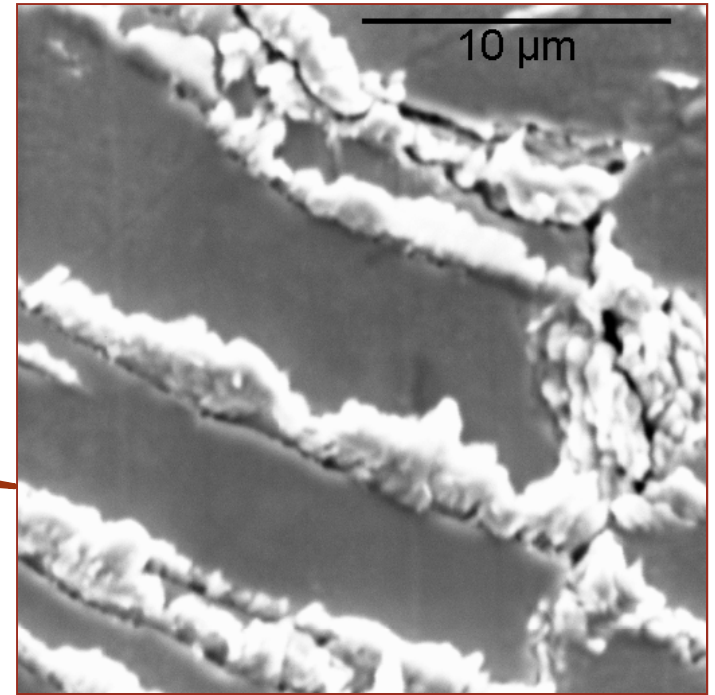
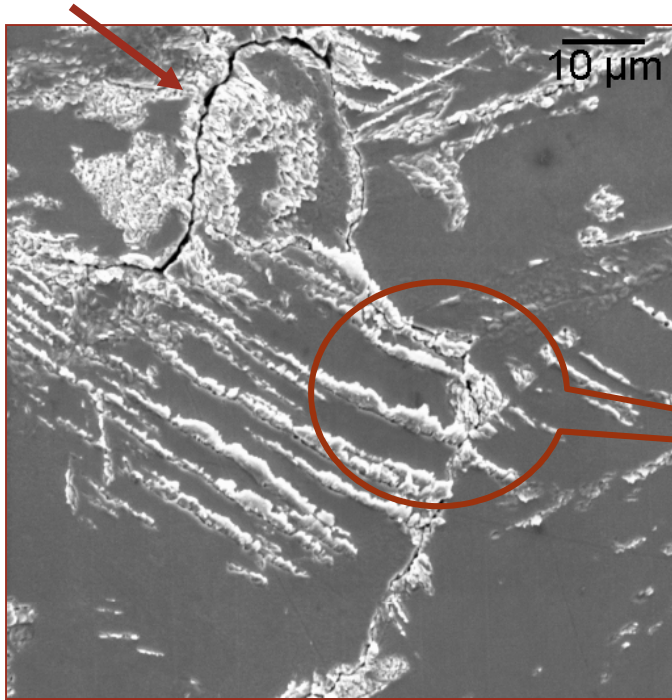


## Photonic Band Gap Single Cell Structure (MIT Collaboration: R. Marsh, M. Shapiro, R. Temkin)

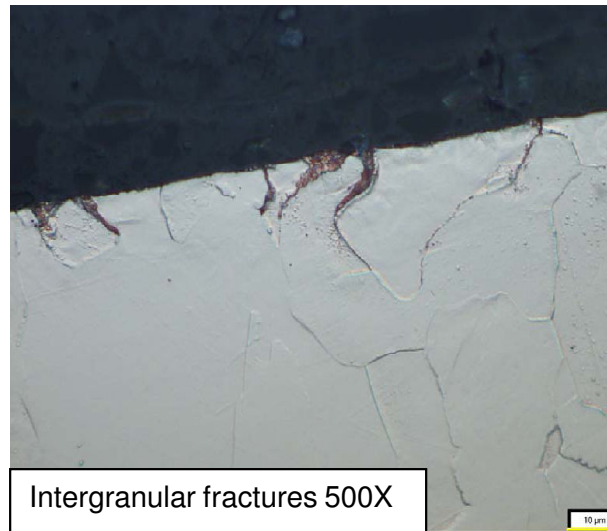


Intergranular fracture

Copper (CERN)



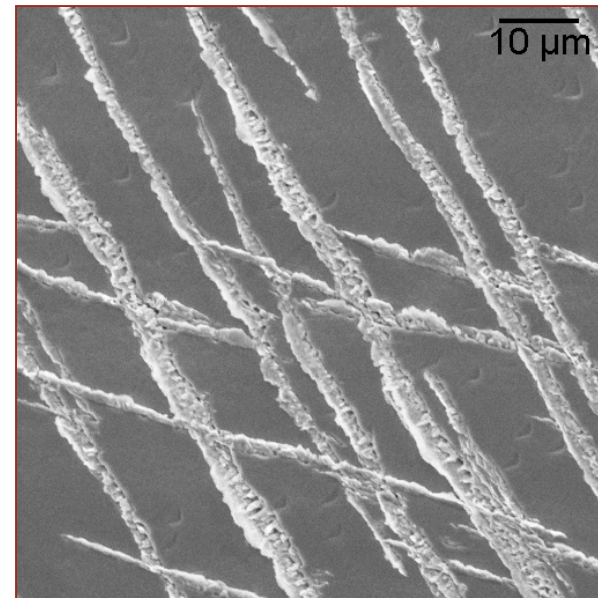
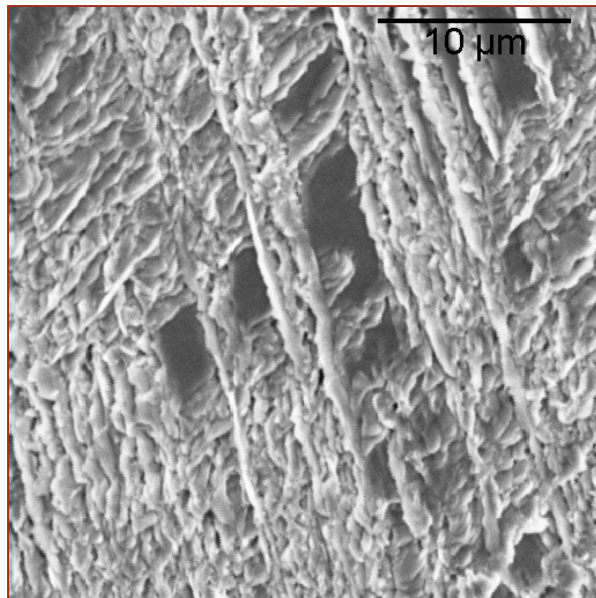
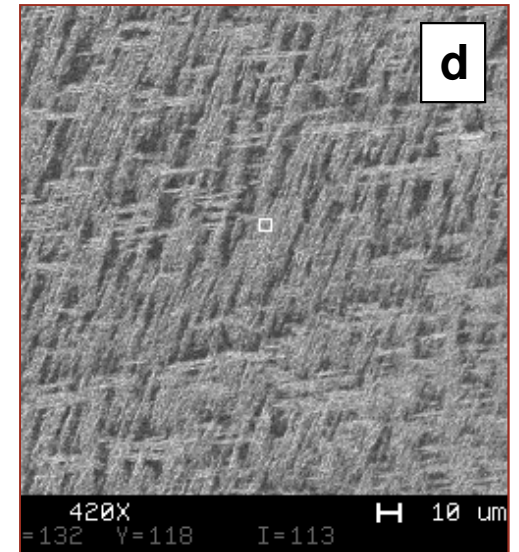
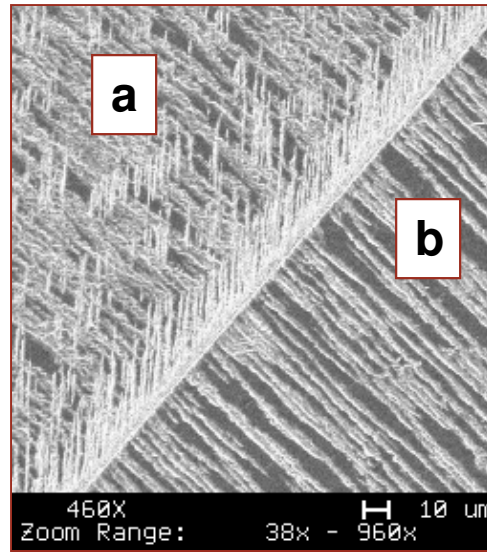
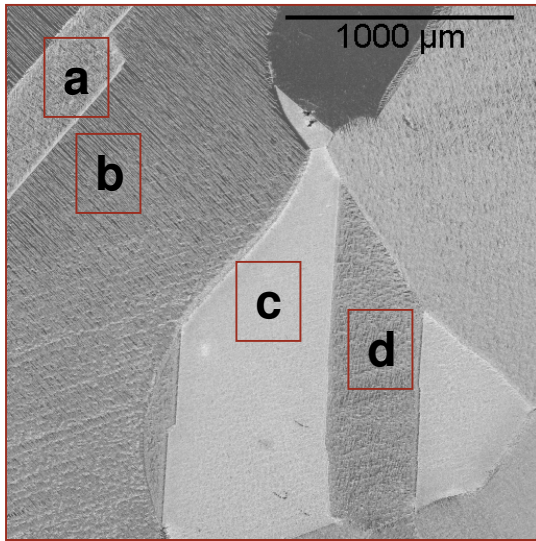
Transgranular fractures

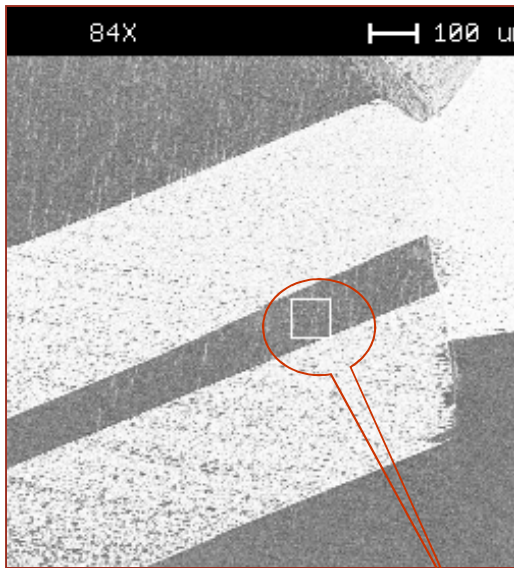


Intergranular fractures 500X

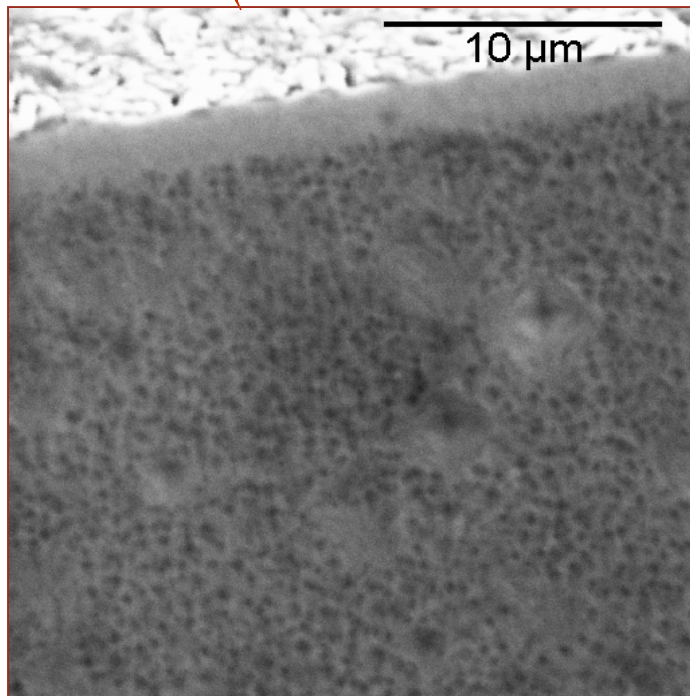


# HIP2 Copper (KEK)

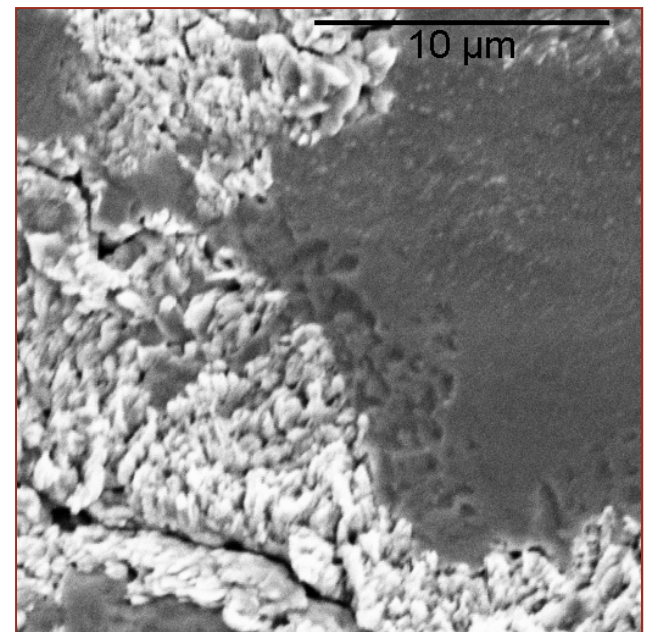
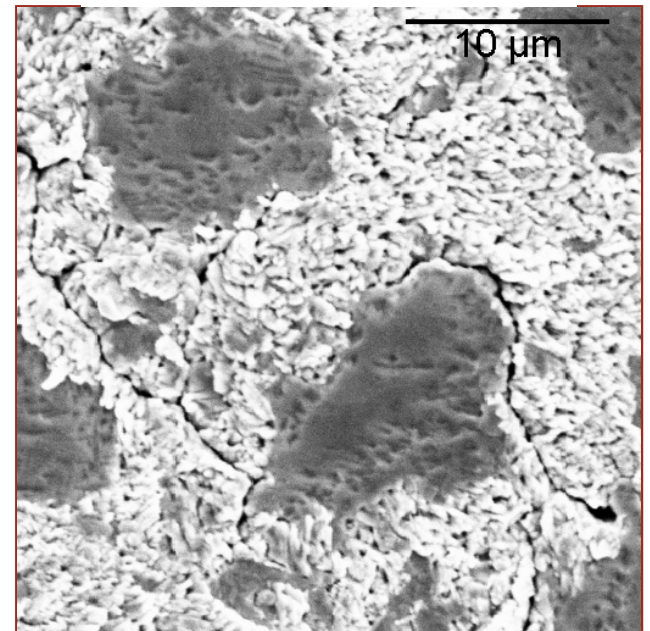




HIP2 Cu (KEK)



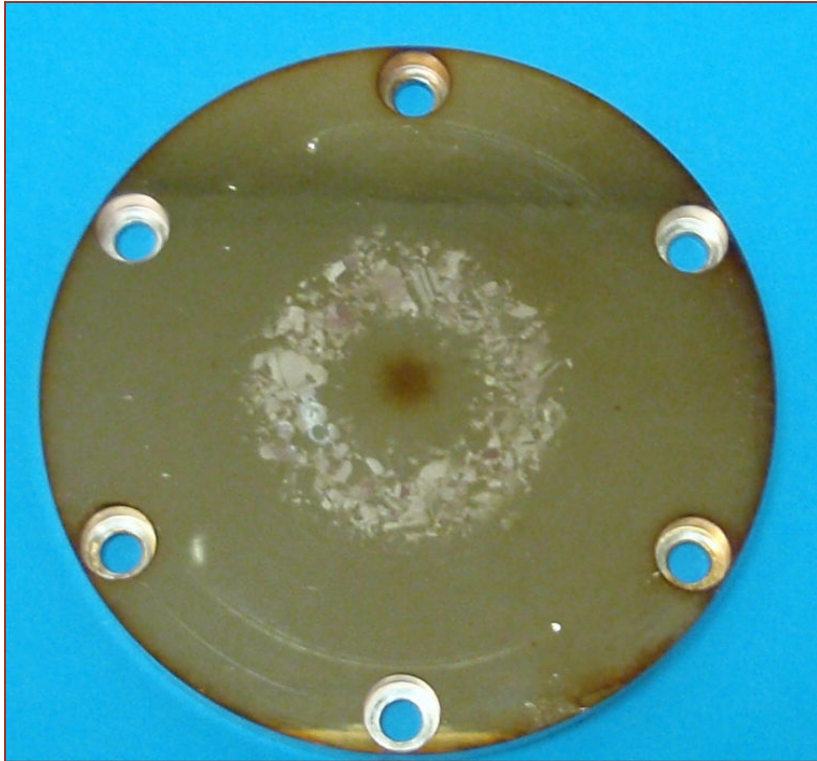
E-Deposited Cu (KEK)



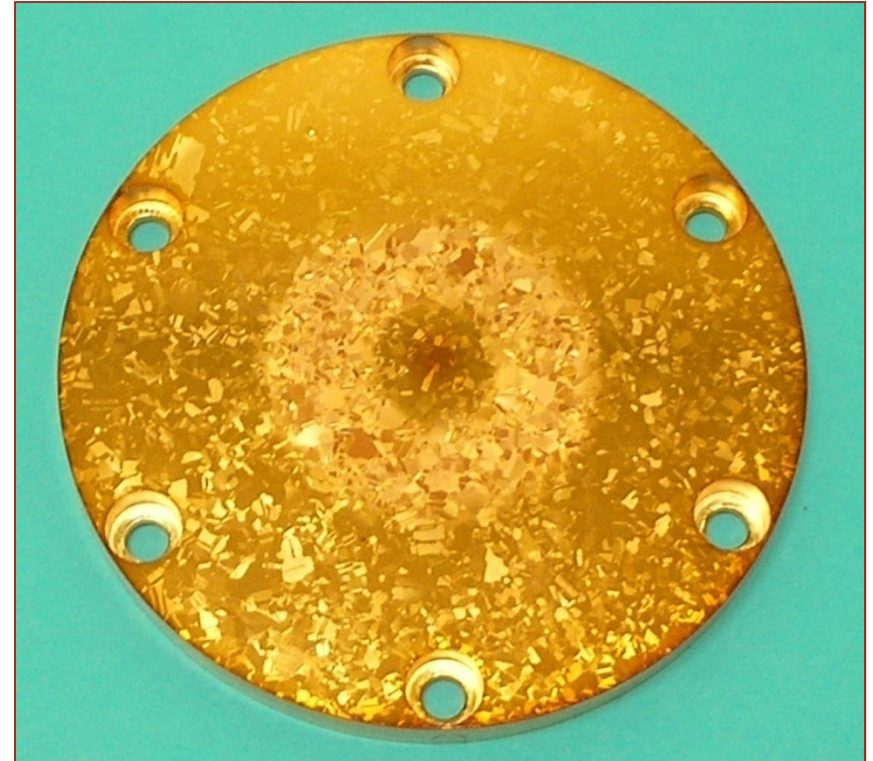


## Hot Isostatic Pressed Copper (KEK): After RF Testing (T=110°C)

HIP1 Copper (KEK): No Etch

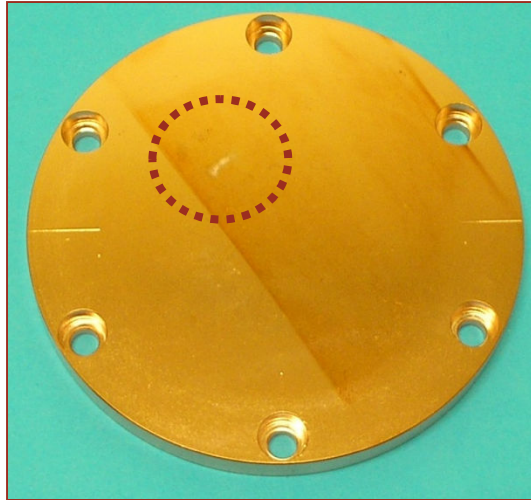


HIP2 Copper (KEK): Etched

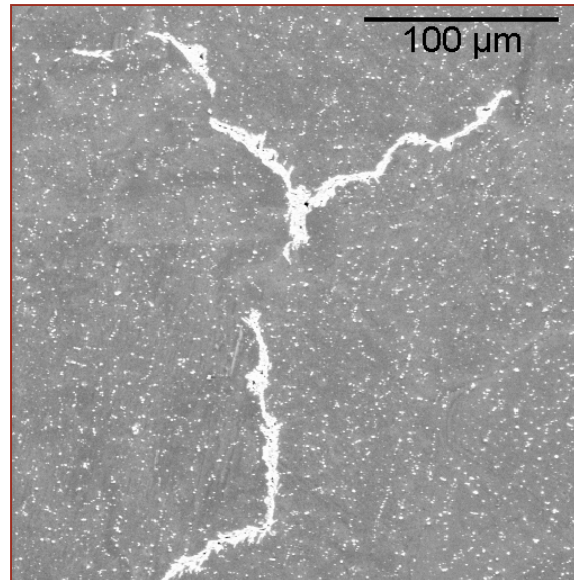
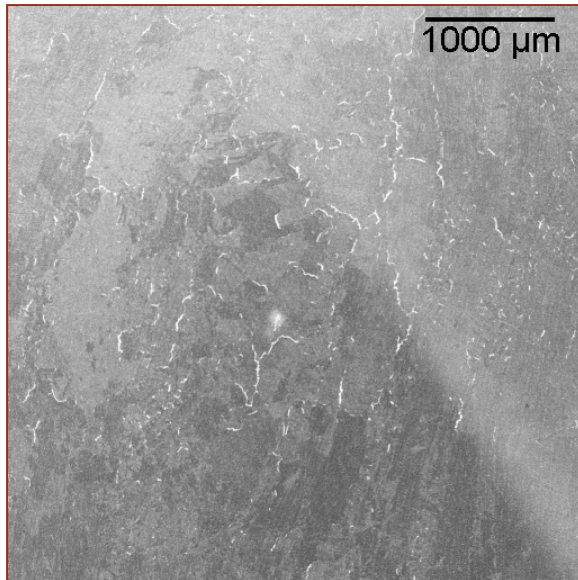
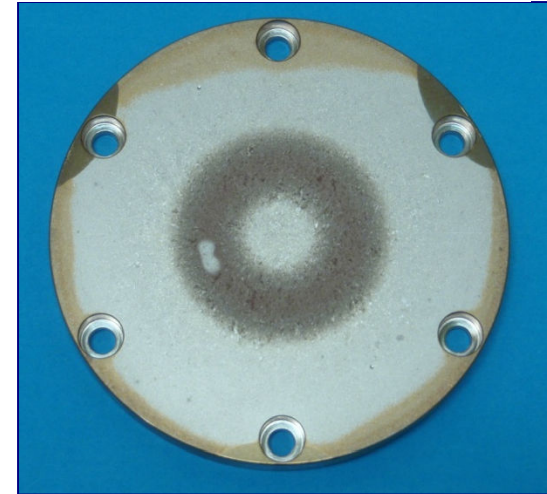


## Two CuCr (SLAC): After RF Testing (T=110°C)

CuCr\_102 No Heat Treatment

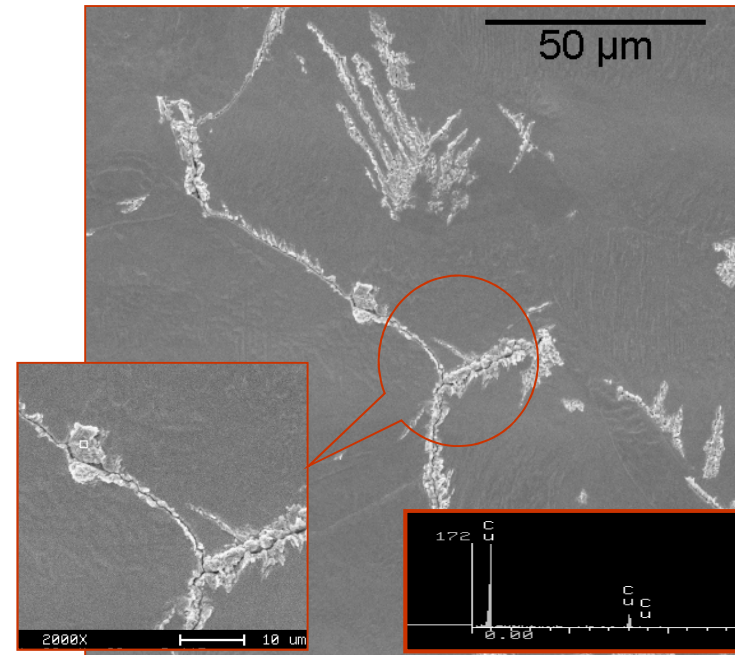
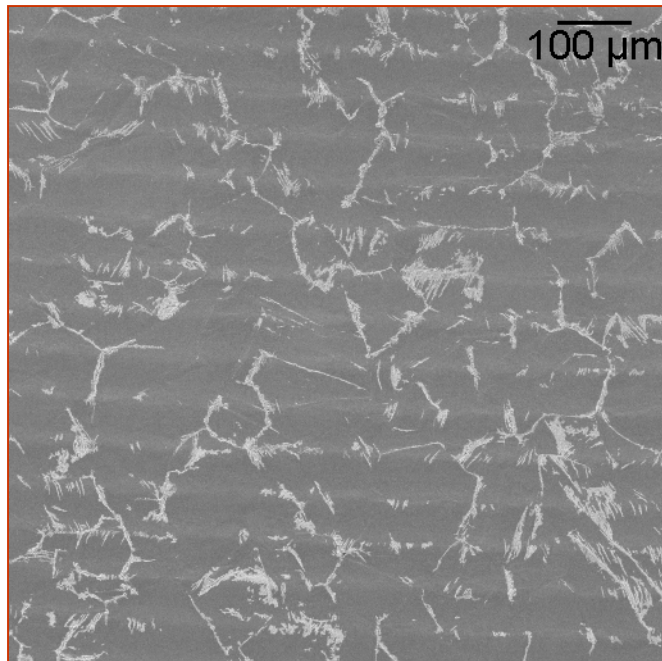
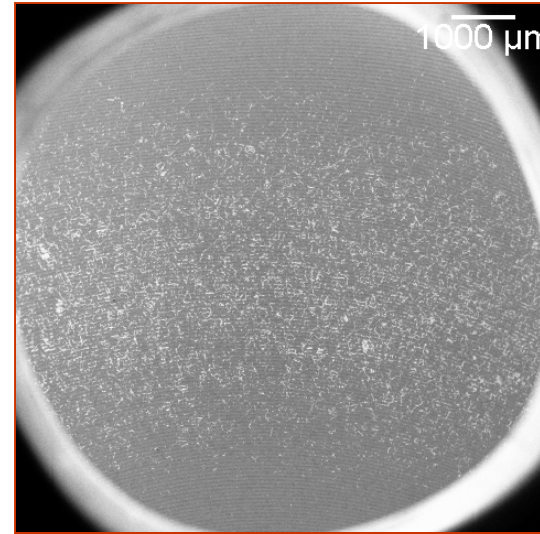


CuCr\_101 Heat Treated  
988°C Braze Cycle



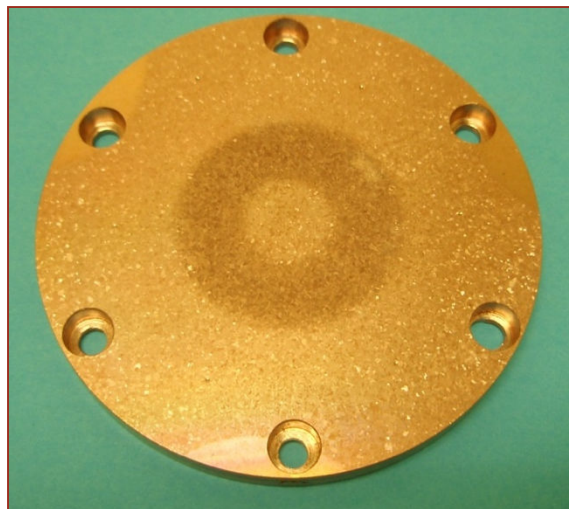


# CuAg (SLAC): After RF Testing (T=110°C)



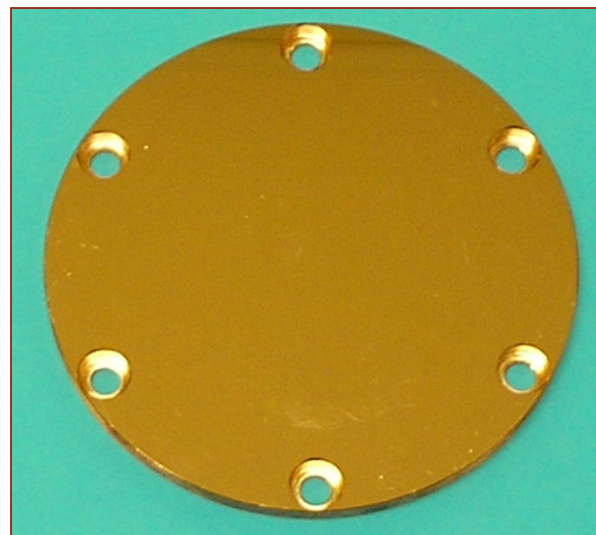
**CuZr2-2: Sample Provided by CERN  
and Annealed at SLAC**

**T=110°C**

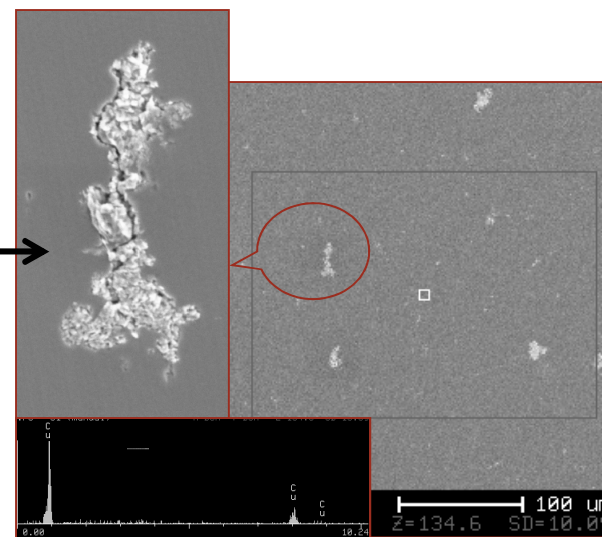
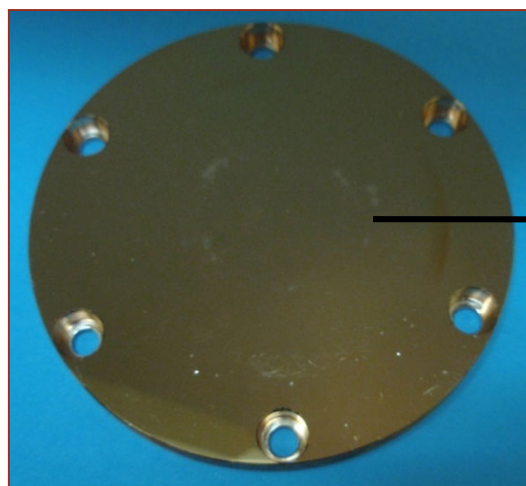


**CuZr3-2 Cold Worked (CERN)**

**T=110°C**

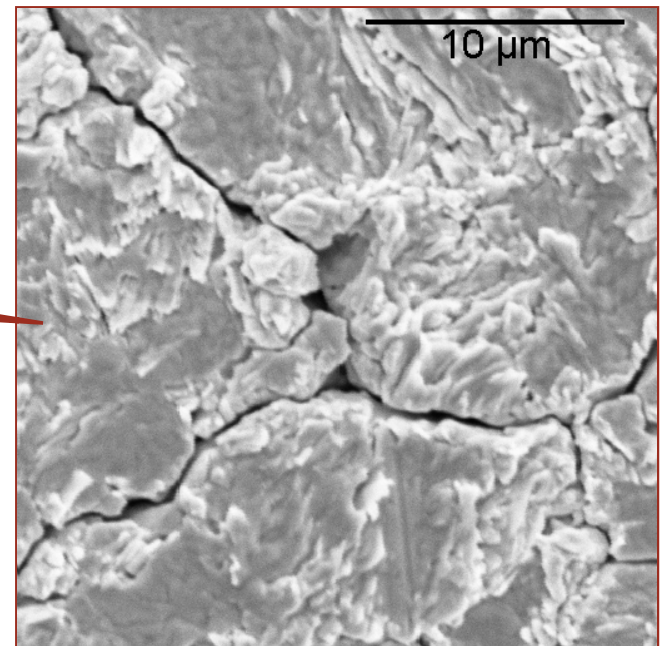
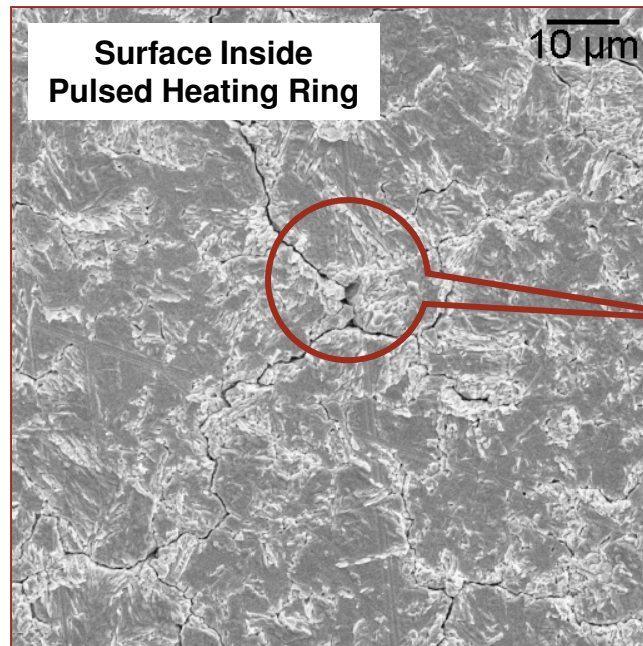
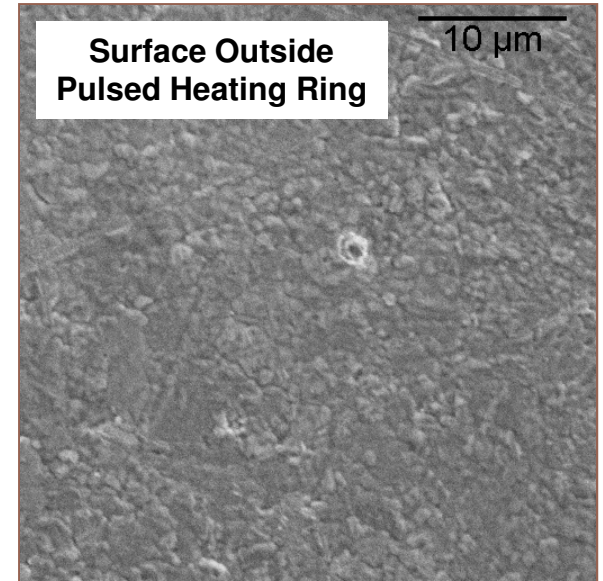
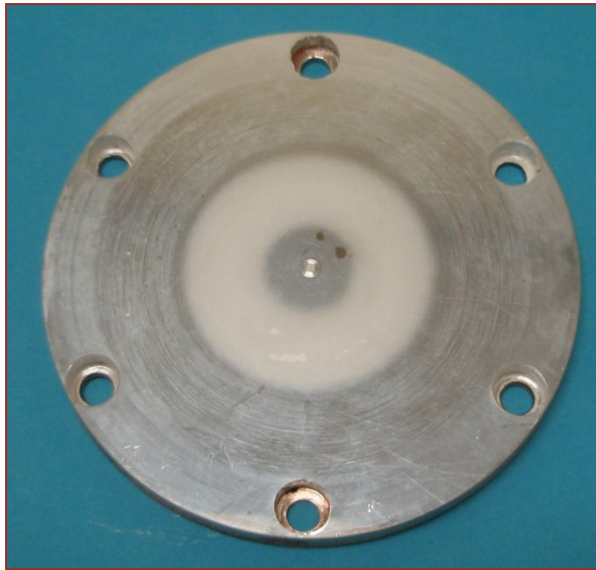


**T=150°C**



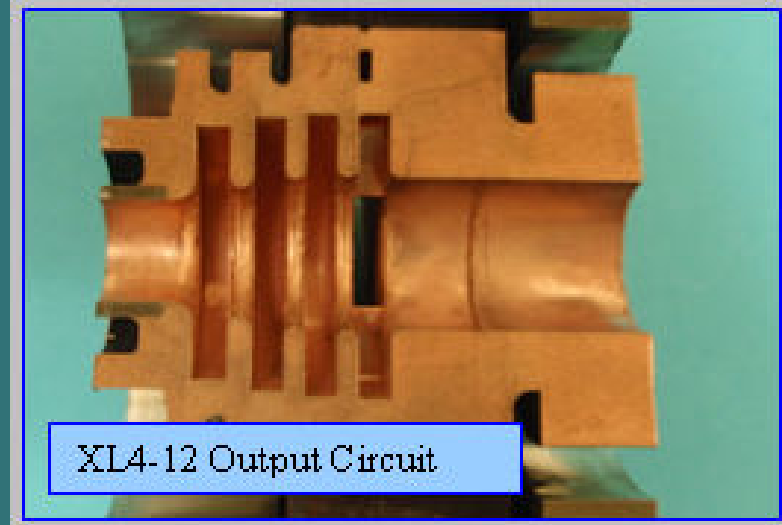


# Silver Plated Copper (KEK): After RF Test (T=110°C)

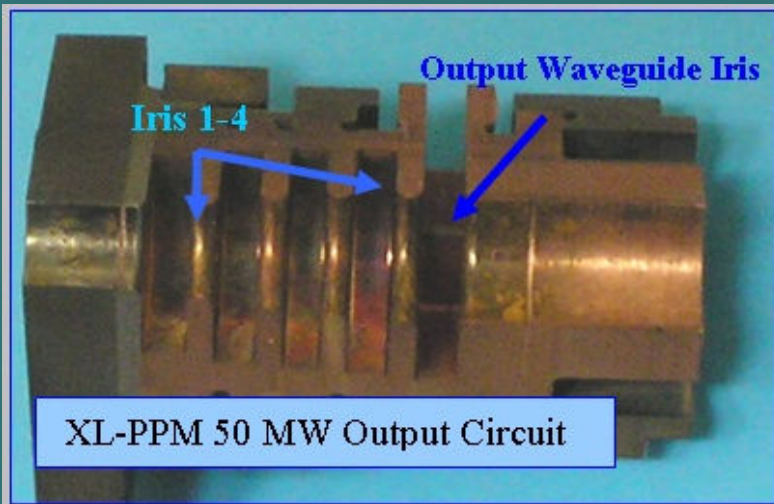


# SLAC X-Band Klystron Output Circuits

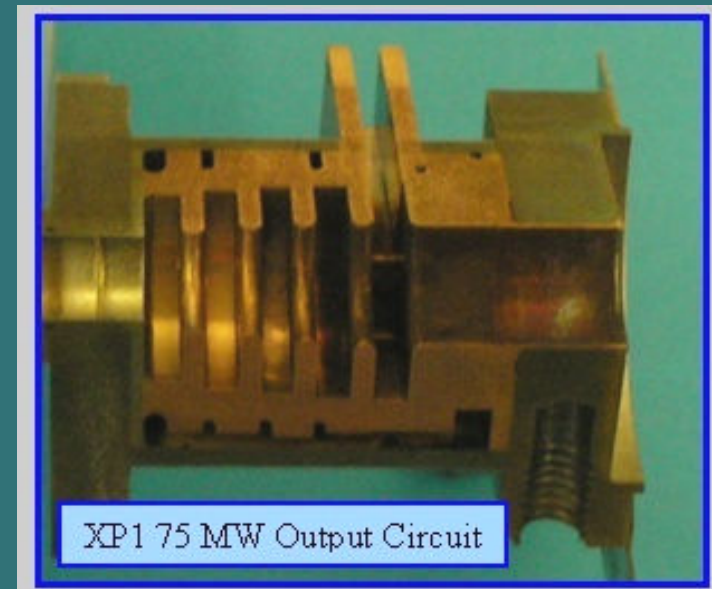
## 4-Cell (Solenoid)



## 5-Cell (PPM)

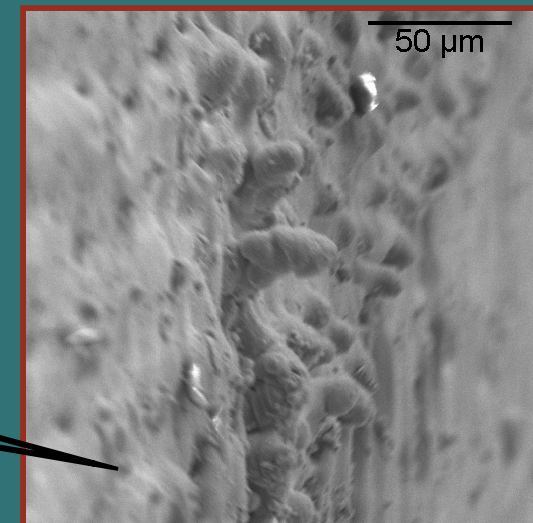
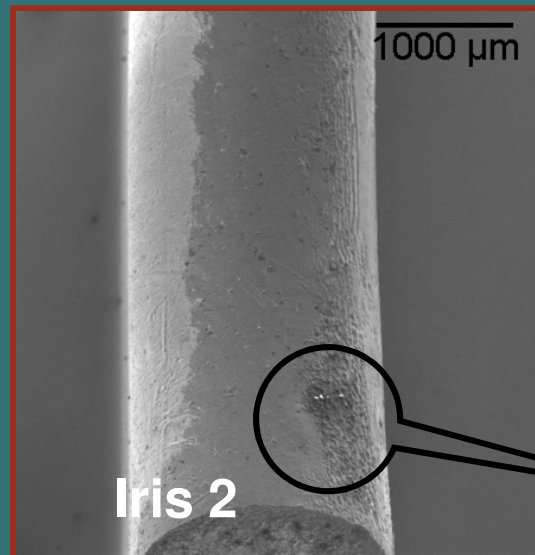
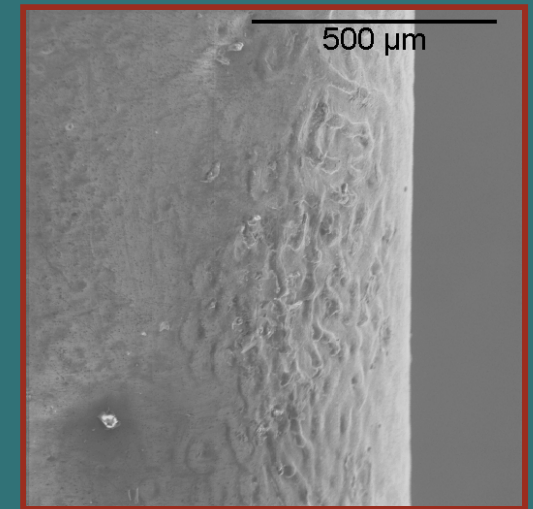
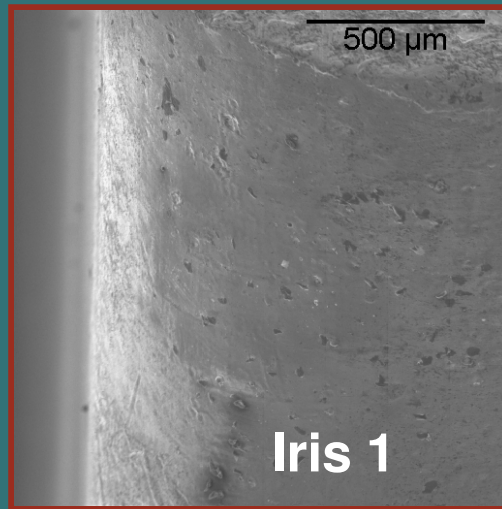
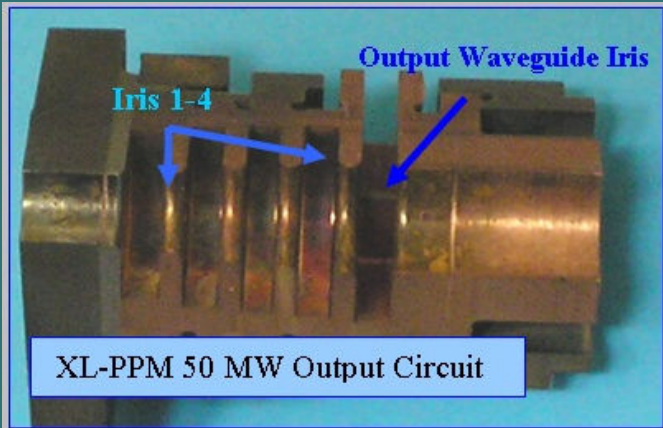


## 5-Cell (PPM)

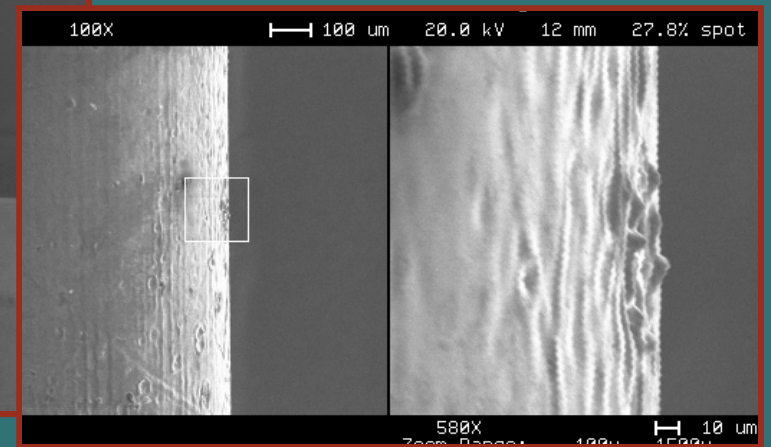
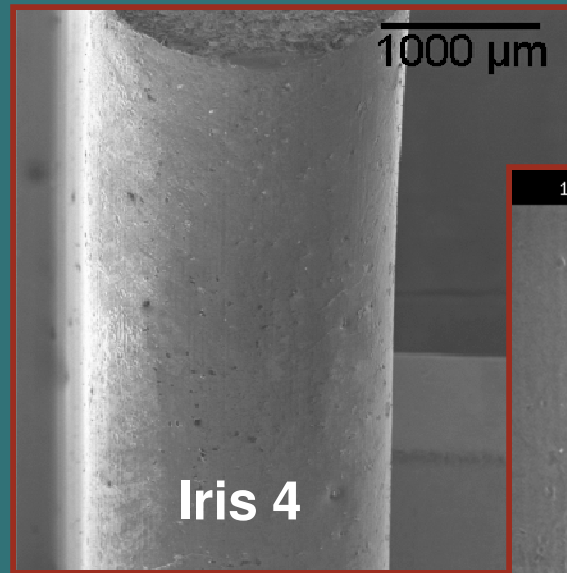
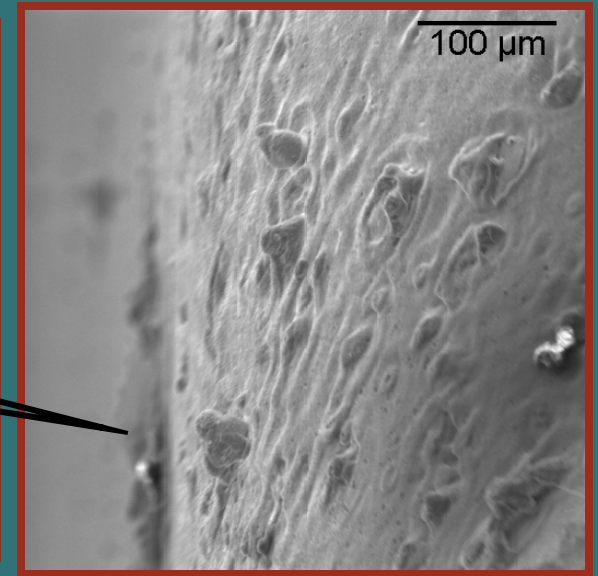
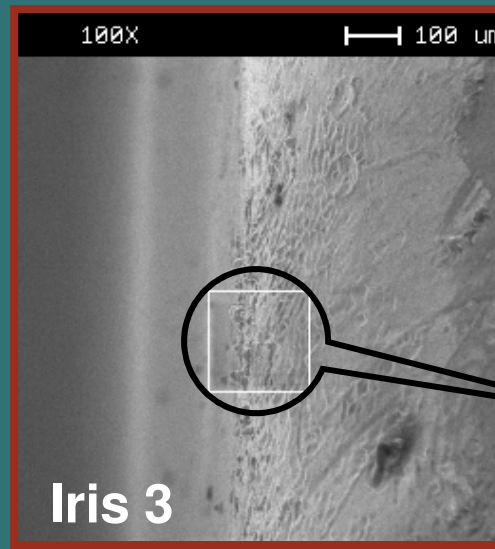
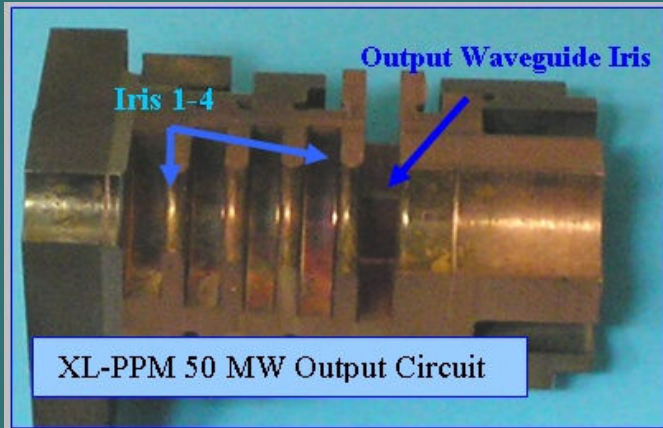




# 50 MW PPM Klystron: XL-PPM

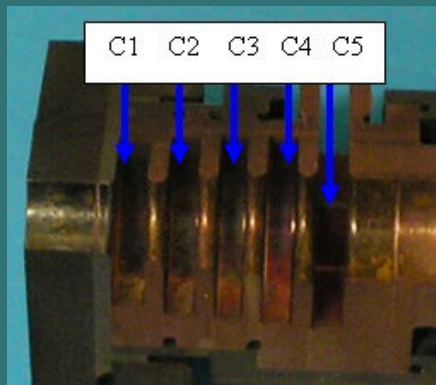


# 50 MW PPM Klystron: XL-PPM

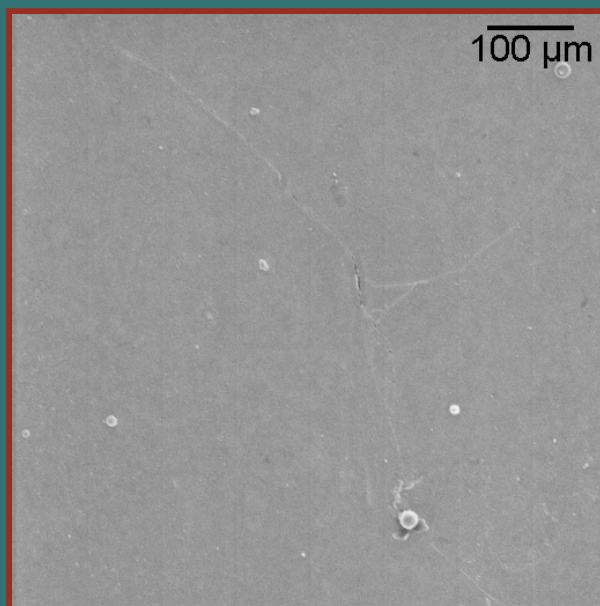




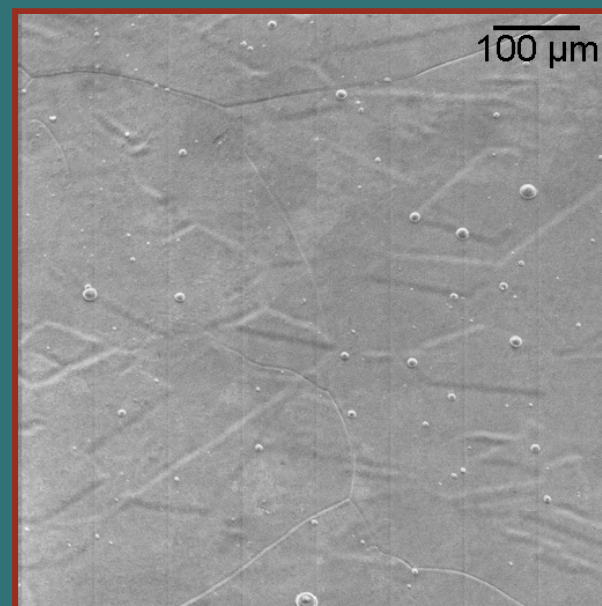
# 50 MW PPM



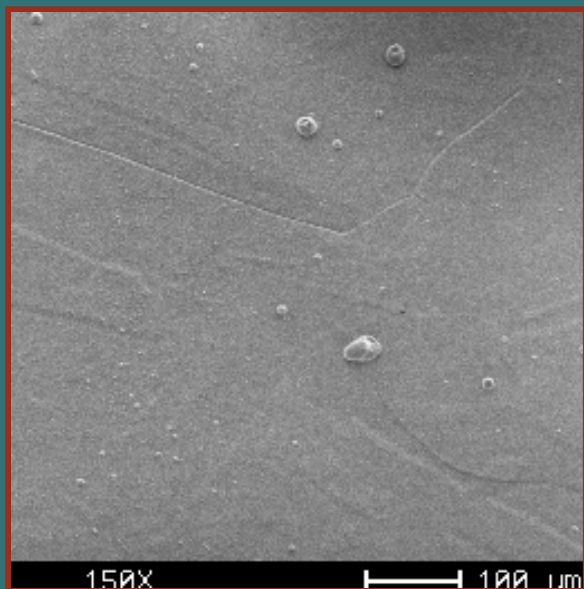
## Cell 1



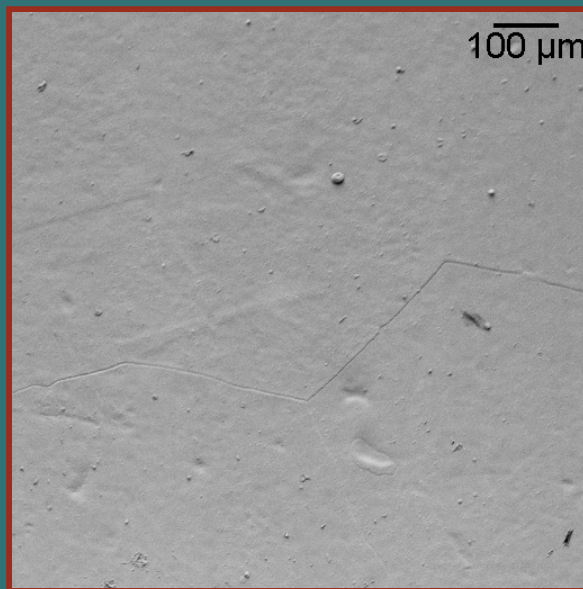
## Cell 2



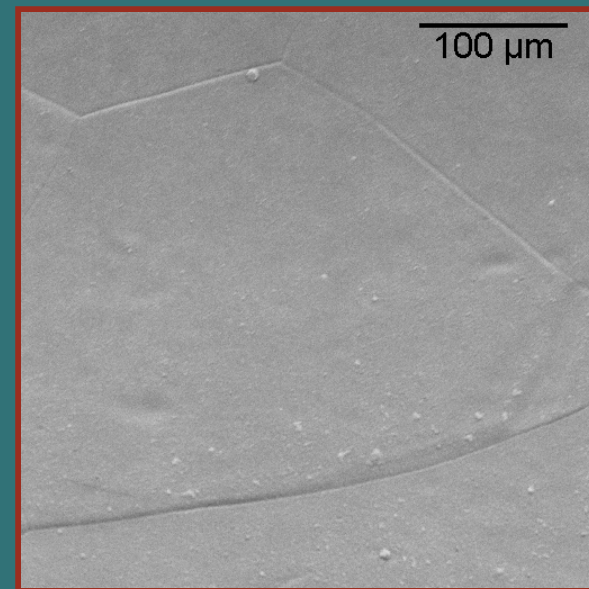
## Cell 3



## Cell 4

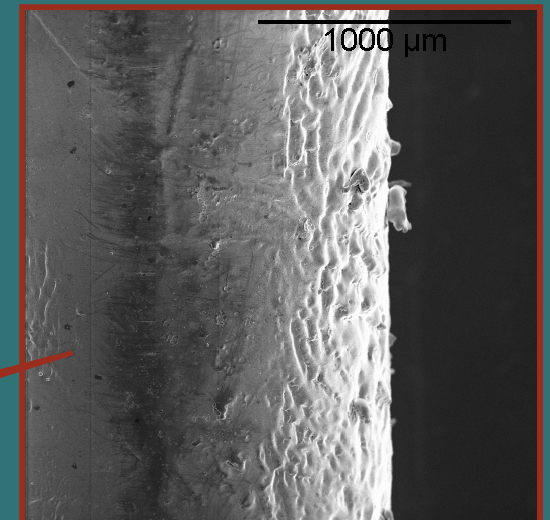
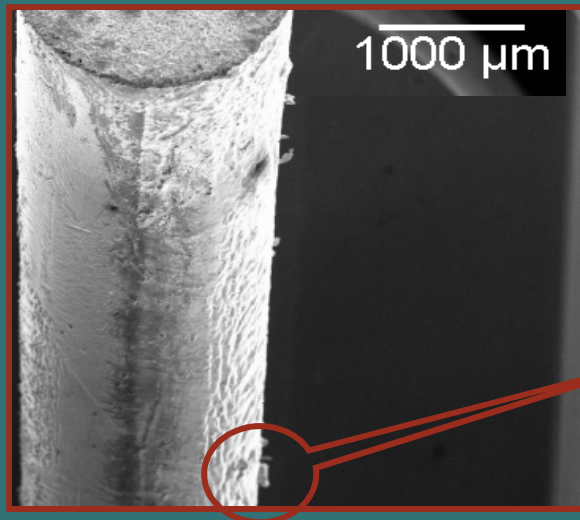
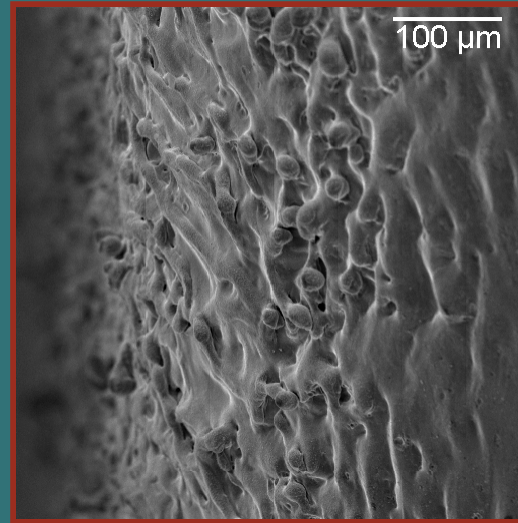
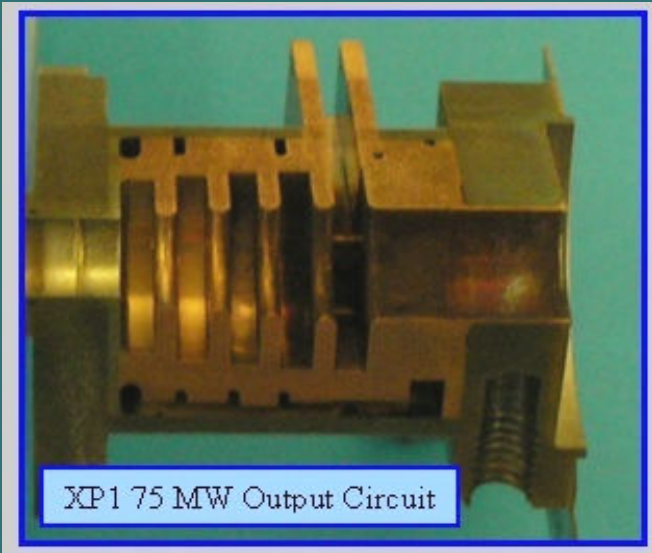


## Cell 5



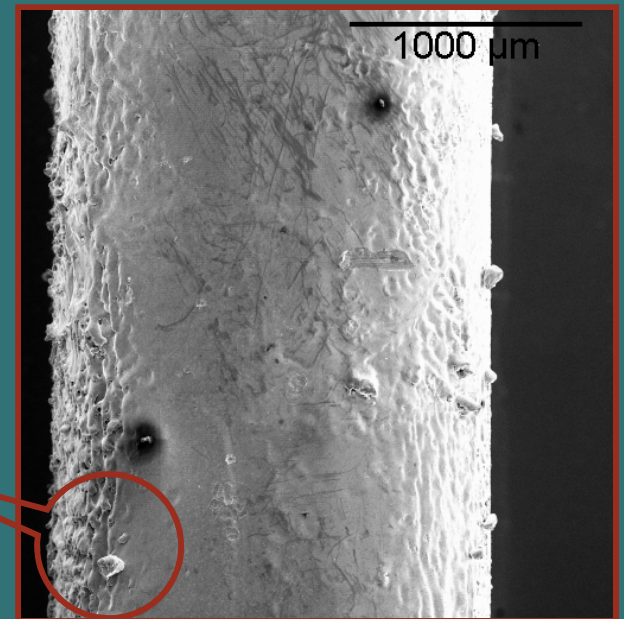
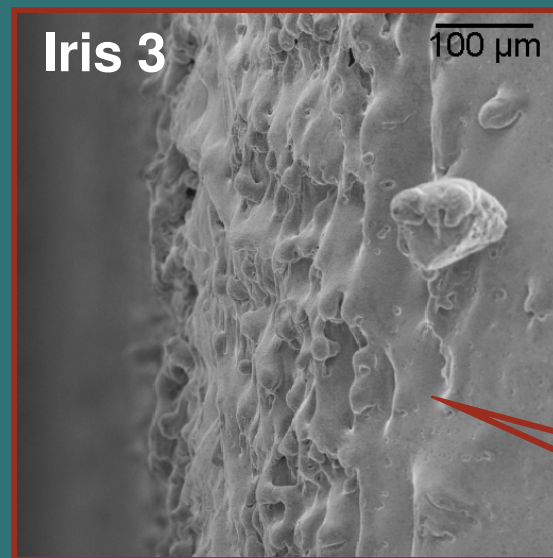
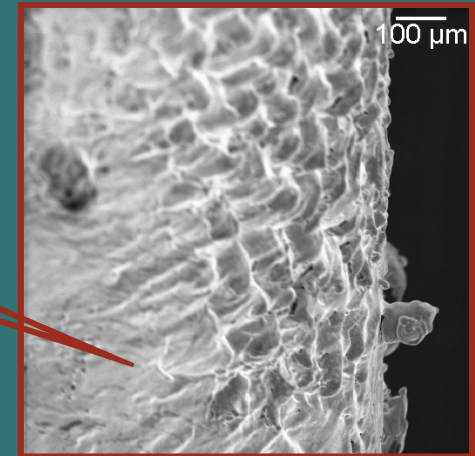
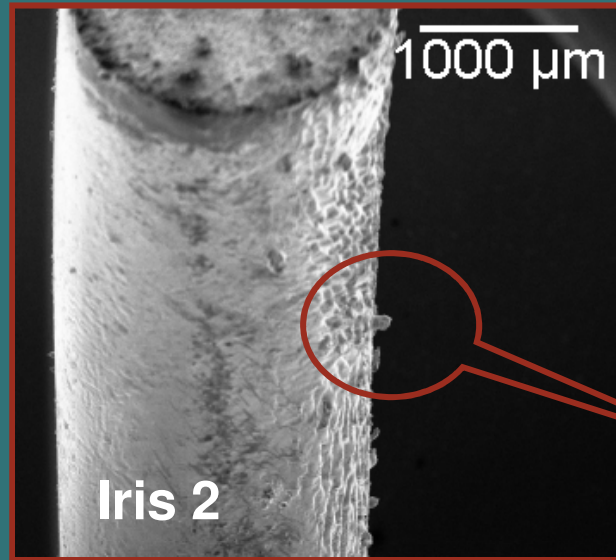
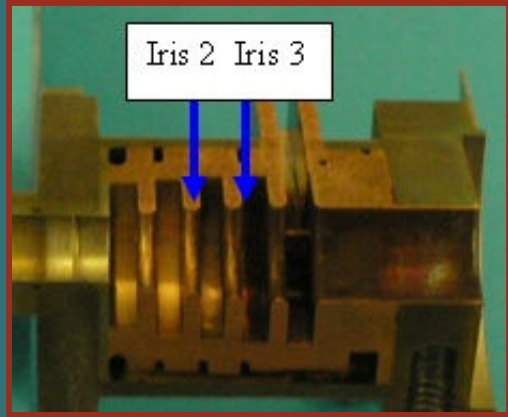
# 75 MW PPM Klystron: XP1

## Iris 1

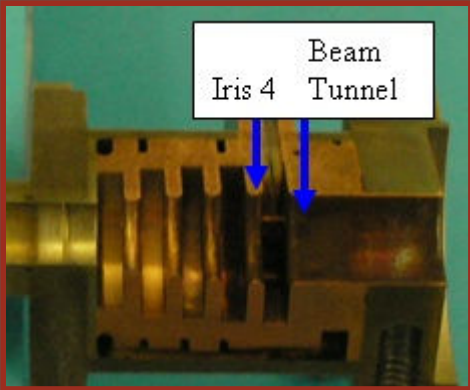




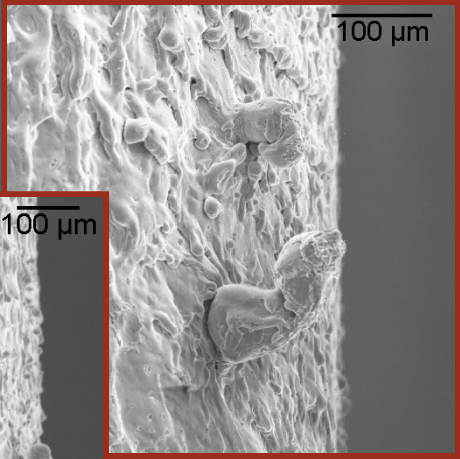
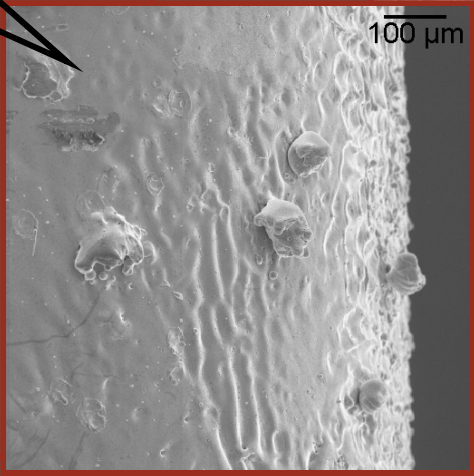
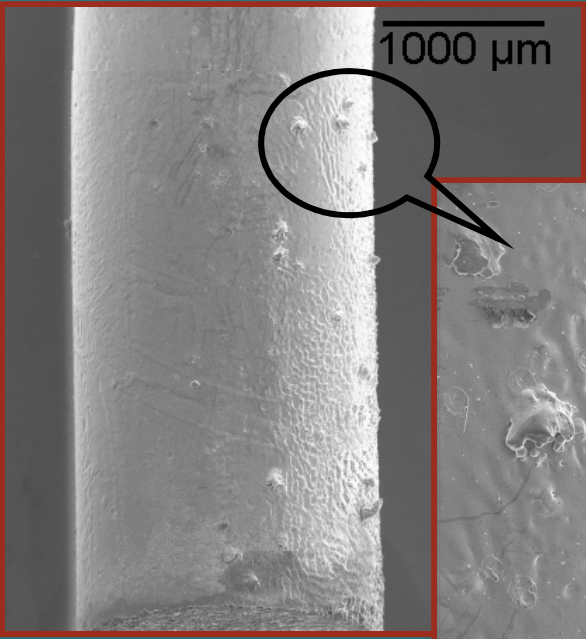
# 75 MW PPM Klystron: XP1



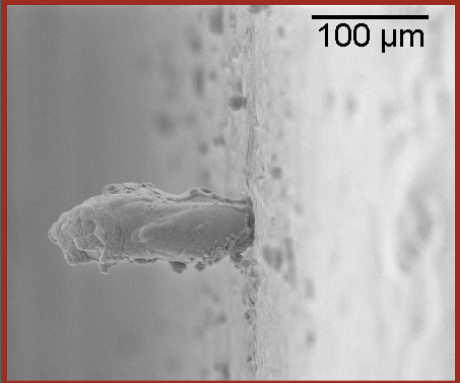
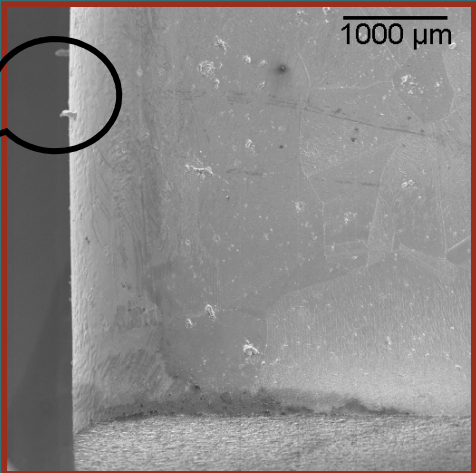
# 75 MW PPM Klystron: XP1



Iris 4

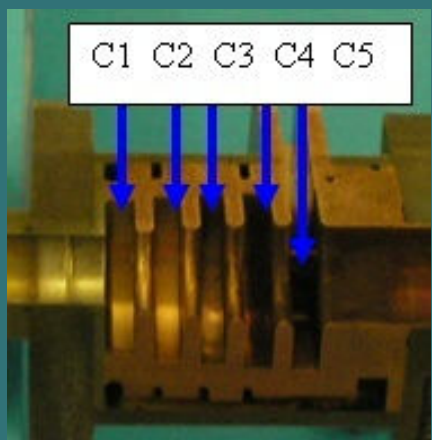


Beam  
Tunnel

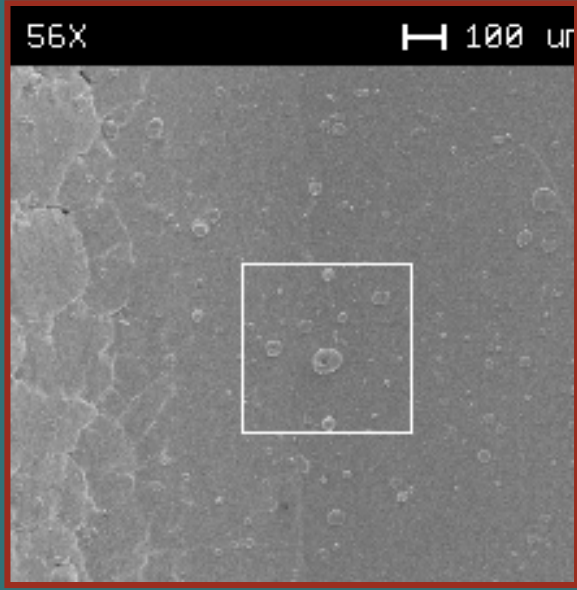




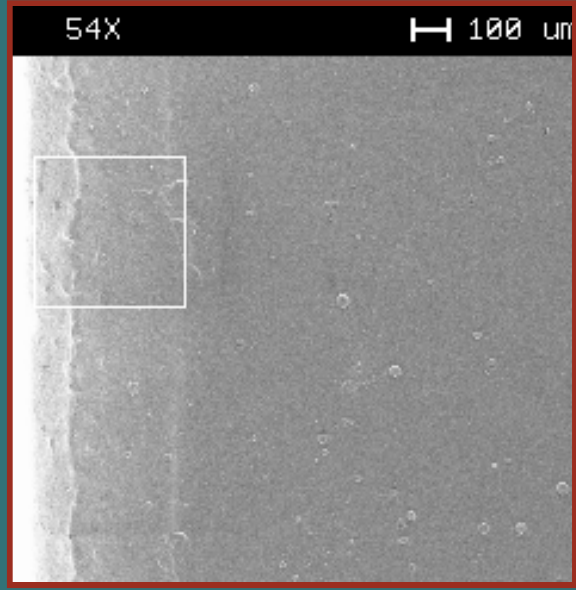
75 MW PPM



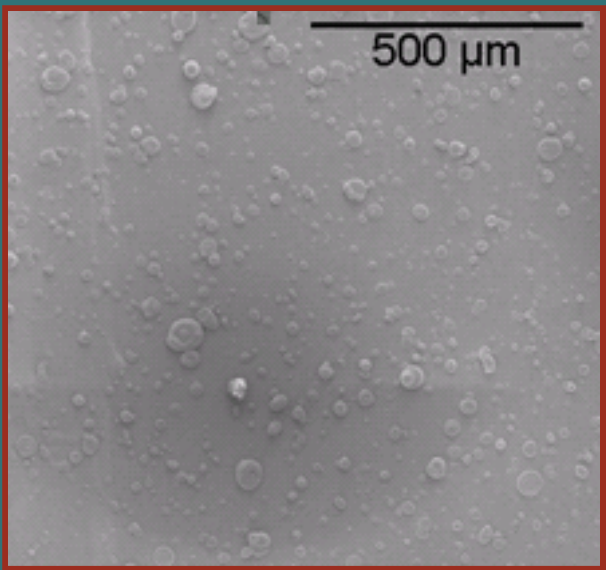
Cell 1



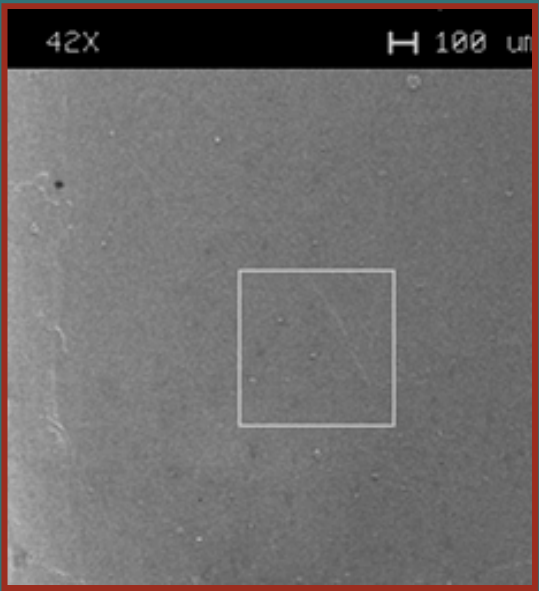
Cell 2



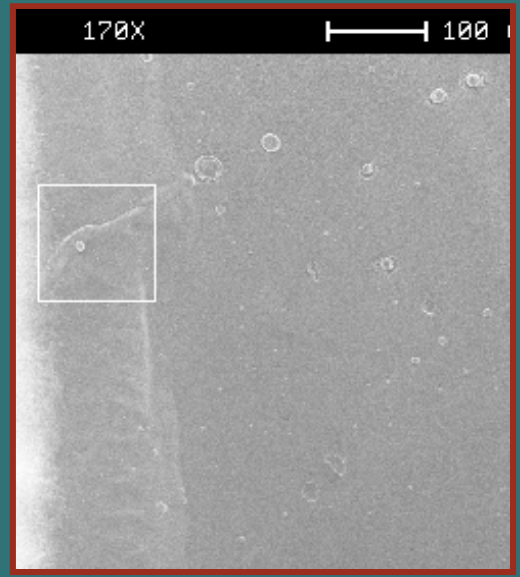
Cell 3



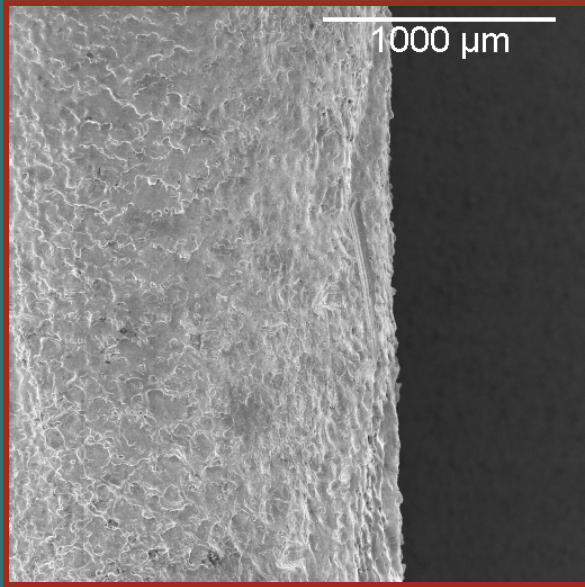
Cell 4



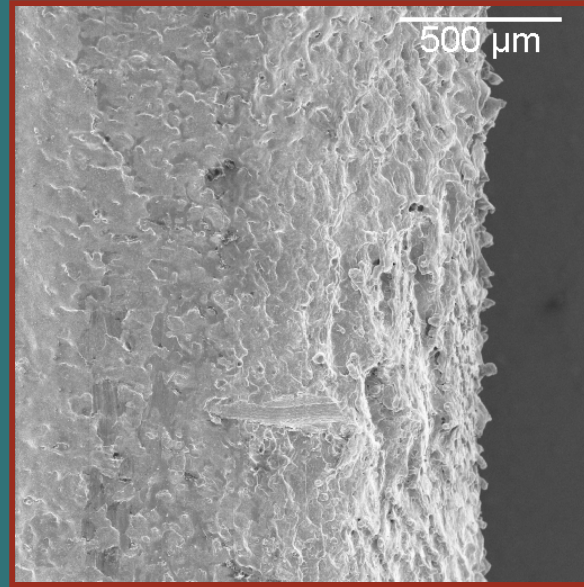
Cell 5



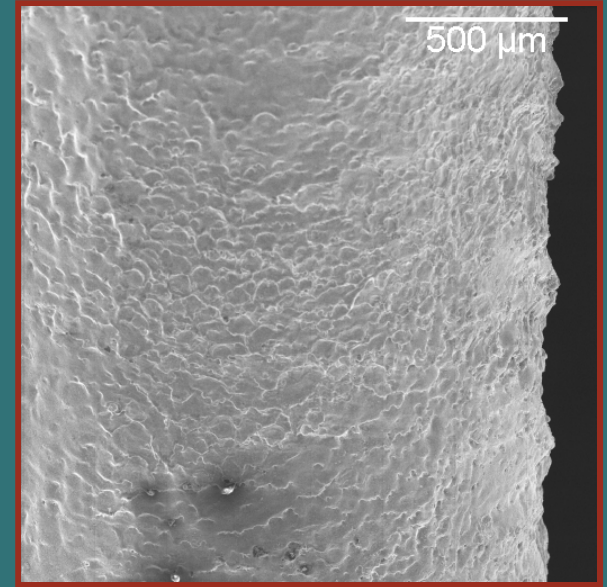
# XL4-12



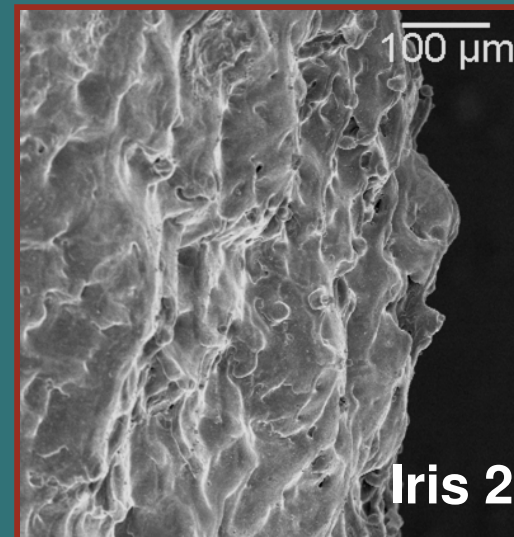
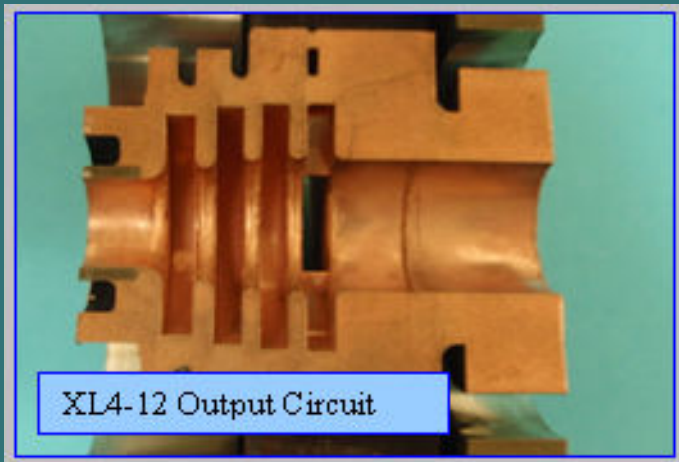
**Iris 1**



**Iris 2**



**Iris 3**

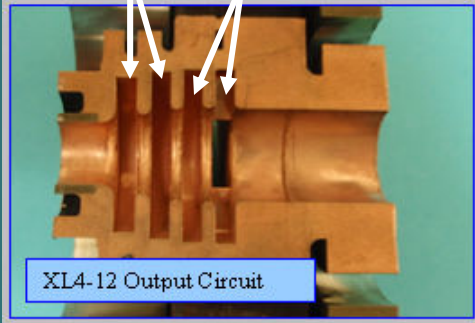


**Iris 2**

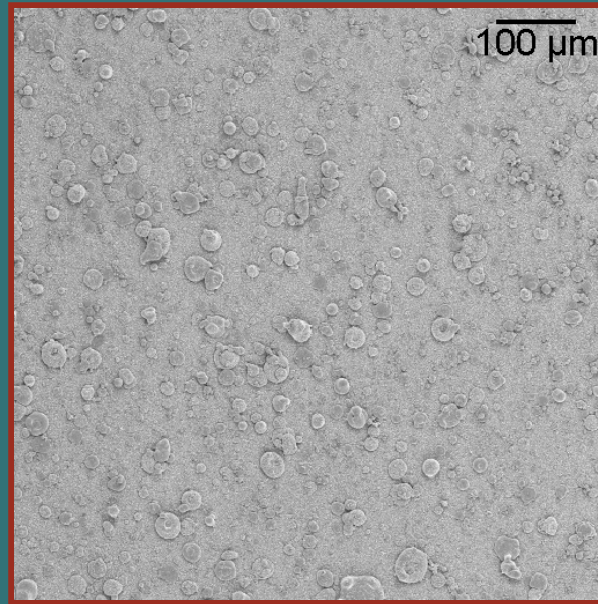


# XL4-12

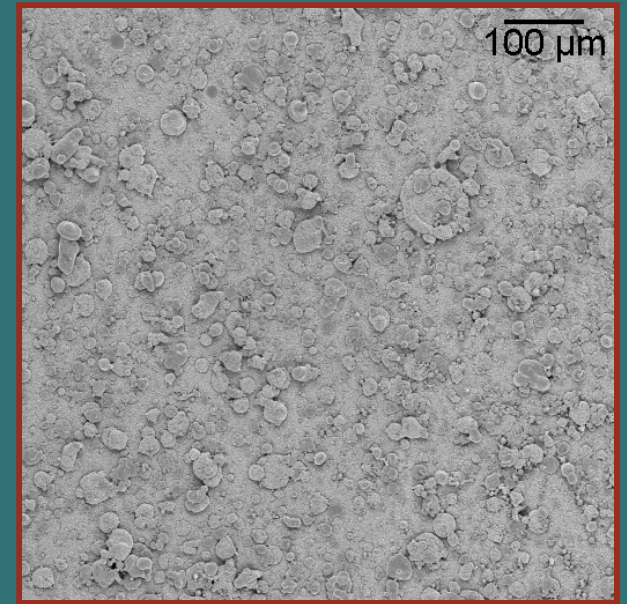
Cell 1, 2      Cell 3, 4



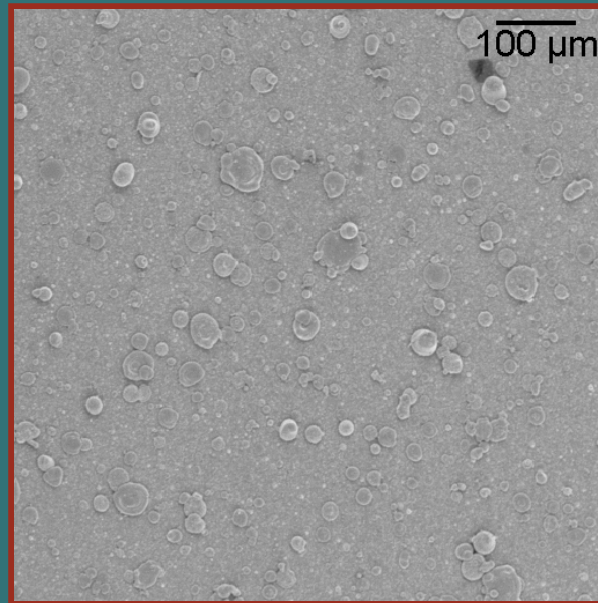
## Cell 1



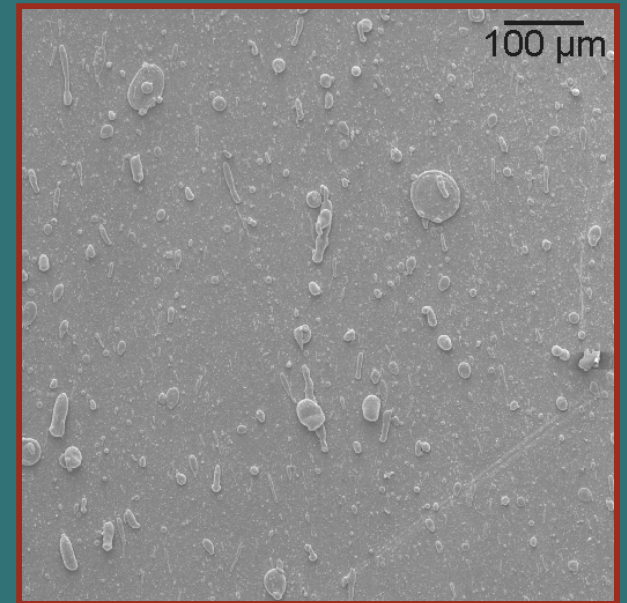
## Cell 2



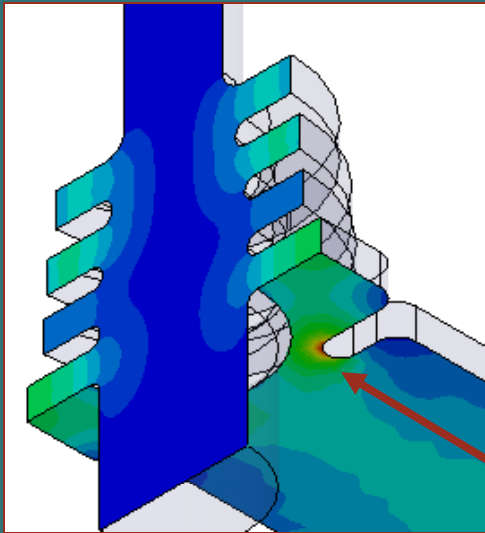
## Cell 3



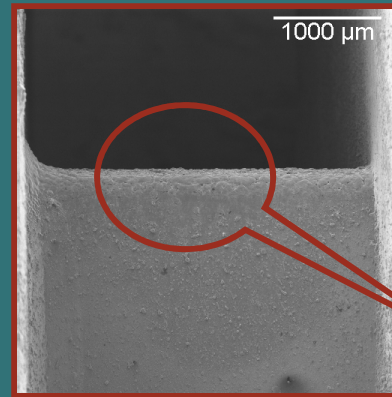
## Cell 4



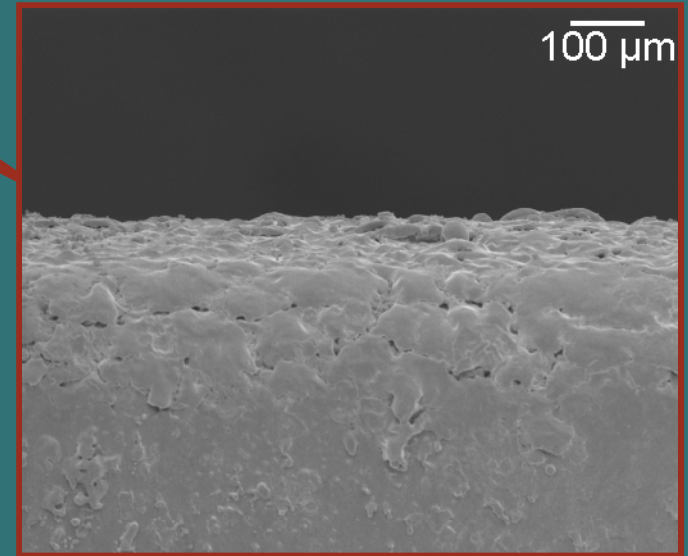
# Output Waveguide Coupler Iris



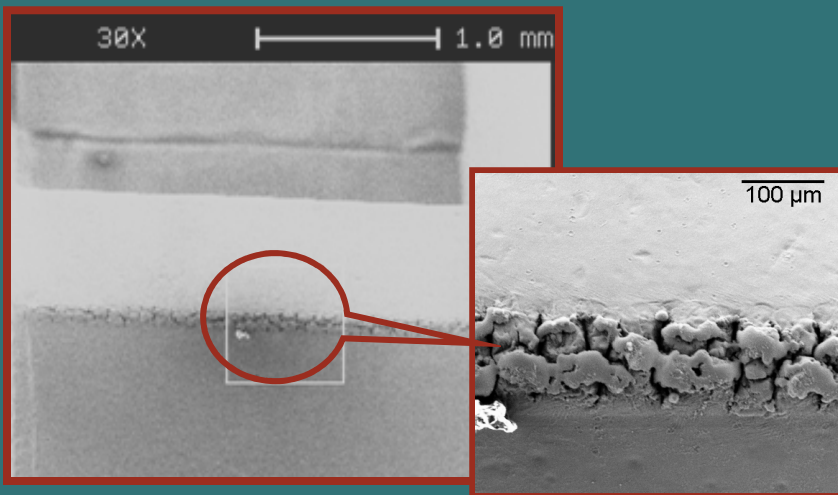
waveguide iris  
XL5 = 4x XL4



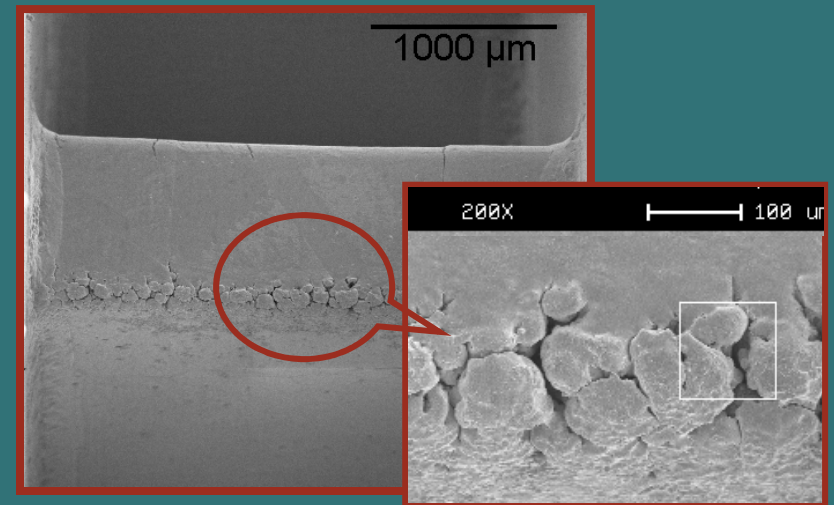
XL4-12



50 MW XL-PPM

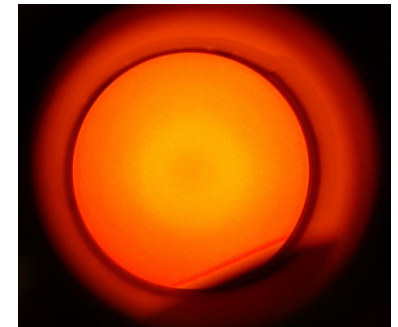
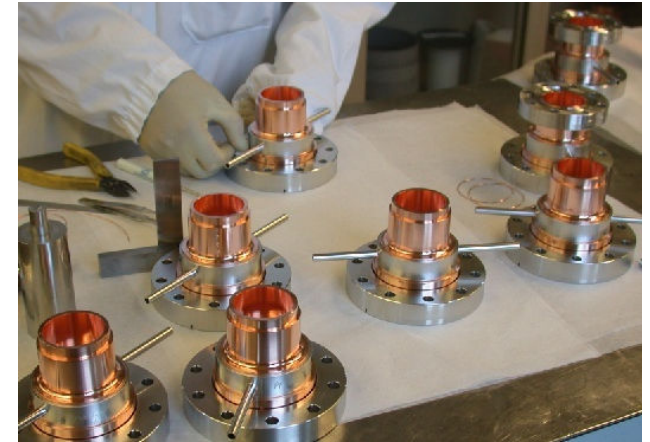
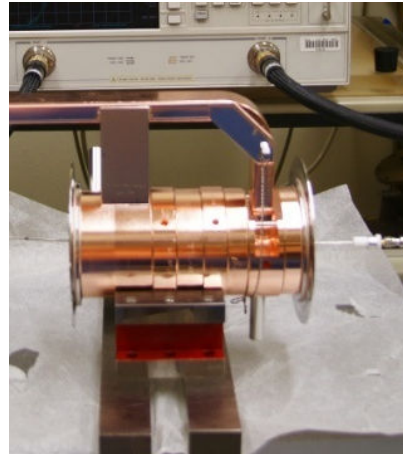
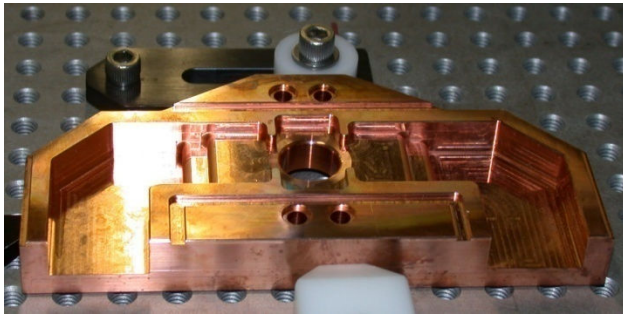
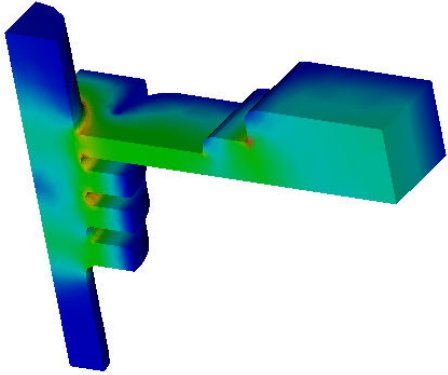


75 MW XP1





**XL5 Status:** The design of the structure is complete. The impedance transformers, bends, combiner, mode converters and window are in fabrication

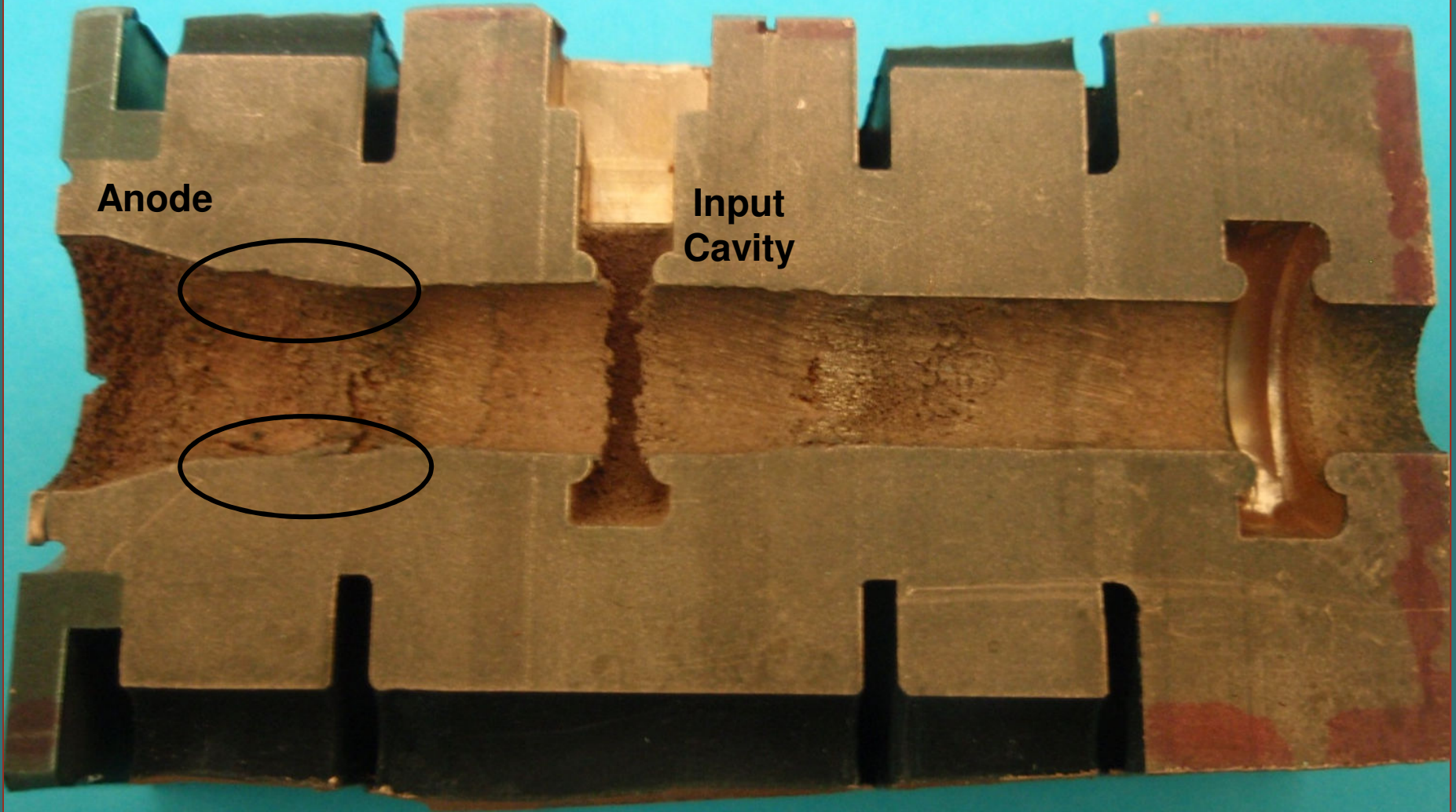


**XL5 is scheduled to be shipped to CERN in February 2010**

# XL4-7 Input Circuit

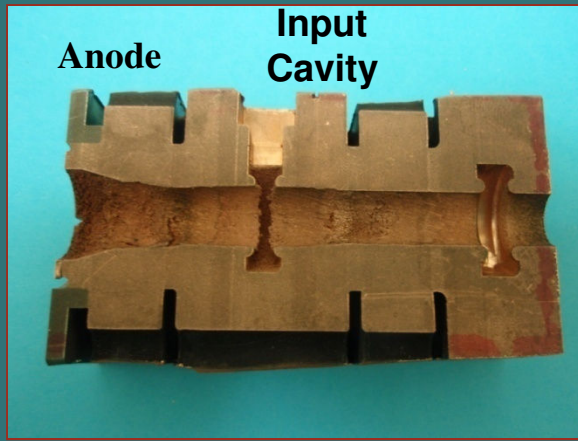
Anode

Input  
Cavity





# XL4-7 Input Circuit



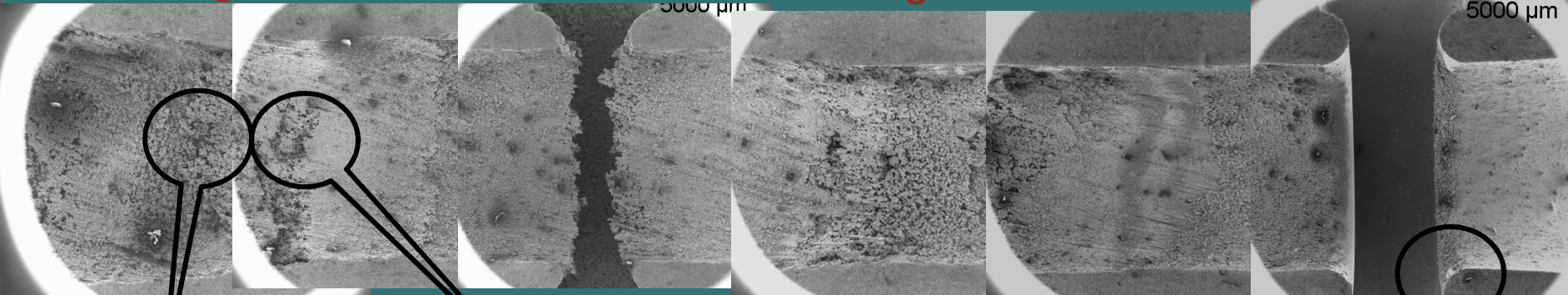
← Anode

Rough

Smooth

Rough

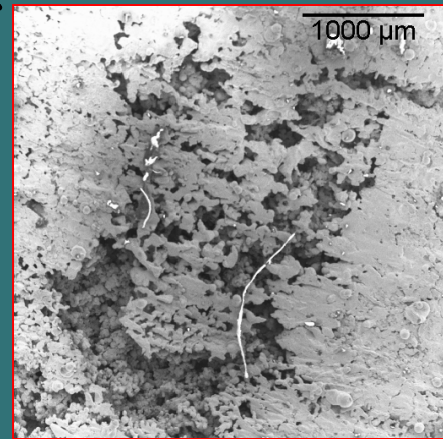
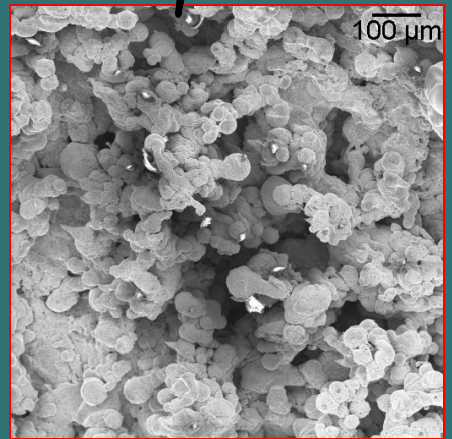
Smooth



A

B

C





XL4-7

